2023 IEEE 36th International Conference on Micro Electro Mechanical Systems (MEMS 2023)

Munich, Germany 15-19 January 2023

Pages 1-601



IEEE Catalog Number: ISBN:

CFP23MEM-POD 978-1-6654-9309-3

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 IEEE Catalog Number:
 CFP23MEM-POD

 ISBN (Print-On-Demand):
 978-1-6654-9309-3

 ISBN (Online):
 978-1-6654-9308-6

ISSN: 1084-6999

Additional Copies of This Publication Are Available From:

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TABLE OF CONTENTS

Monday, 16 January

All times are Central European Time (CET).

1	X	I	ρÌ	ما	n	n	n	e	A	Ы	Ы	r	ρ	c	6

08:00 MEMS 2023 Conference Chairs

Núria Barniol, *Universitat Autonoma de Barcelona, SPAIN* Franz Lärmer, *Robert Bosch GmbH, GERMANY*

- IEEE Fellows Recognition in the Field of MEMS/NEMS
 - IEEE Electron Devices Society Robert Bosch Micro and Nano Electro Mechanical Systems Award
- **08:35** IEEE Electron Devices Society Robert Bosch

Tengteng Lei, Yushen Hu, and Man Wong

Hong Kong University of Science and Technology, HONG KONG

Micro and Nano Electro Mechanical Systems Award Recipient

John H. (Hal) Jerman will accept on behalf of the Gas Chromatograph on a Chip Project.

Plenary Presentation I 08:50 FROM ETCH TO EDGE AI: OPENING NEW HORIZONS WITH SMART SENSOR TECHNOLOGIES 1 Stefan Finkbeiner Bosch Sensortec GmbH, GERMANY Session I - Novel MEMS/NEMS Devices for Computing/Imaging SUB-300 MILLIVOLT OPERATION IN NONVOLATILE 300 NM X 100 NM 09:35 Mohammad Ayaz Masud and Gianluca Piazza Carnegie Mellon University, USA A FAST AND ENERGY-EFFICIENT NANOELECTROMECHANICAL 09:50 Yong-Bok Lee¹, Min-Ho Gang², Pan-Kyu Choi¹, Su-Hyun Kim¹, Tae-Soo Kim¹, So-Young Lee¹ and Jun-Bo Yoon¹ ¹Korea Advanced Institute of Science and Technology (KAIST), KOREA and ²National NanoFab Center (NNFC), KOREA 10:05 TOWARDS ULTRA-HIGH SPATIAL RESOLUTION SENSING OF GHZ ULTRASOUND USING STRAIN MODULATION OF FIELD EFFECT TRANSISTORS9 Rohan Sanghvi¹, Justin Kuo², Adarsh Ravi¹, and Amit Lal¹ ¹Cornell University, USA and ²Geegah Inc., USA 10:20 A TACTILE SENSOR ARRAY WITH A MONOLITHICALLY

	Session II - BioMEMS I	
11:05	EVALUATION OF LOCAL AND INTERNAL ELASTICITY OF HYDROGEL MATERIALS BY USING LIGHT-DRIVEN GEL ACTUATOR Hibiki Nakajima ¹ , Yuha Koike ¹ , Yoshiyuki Yokoyama ² , Masaya Hagiwara ³ , and Takeshi Hayakawa ¹ ¹ Chuo University, JAPAN, ² Toyama Industrial Technology Research and Development Center, JAPAN, a ³ RIKEN, JAPAN	
11:20	3D PRINTED MINIATURIZED SOFT MICROSWIMMER FOR MULTIMODAL 3D AIR-LIQUID NAVIGATION AND MANIPULATION	. 21
11:35	SELF-DRIVEN CAPILLARIC VISCOMETER FOR DIRECT OR CASCADED BAR GRAPH READ-OUT OF RELATIVE SAMPLE VISCOSITY Daniel Mak ¹ , R. Claude Meffan ^{1,2} , Julian Menges ¹ , Fabian Dolamore ¹ , Conan Fee ¹ , Renwick C.J. Dobson ¹ , and Volker Nock ¹ **Iniversity of Canterbury, NEW ZEALAND and **EXPORT LAND AND CONTROL LAND AND CASCADED CONTROL LAND AND CASCADED CONTROL LAND AND CASCADED CASCADED CONTROL LAND CASCADED CONTROL LAND CASCADED CASCADED CONTROL LAND CASCADED CASCADE	. 25
11:50	A FLEXIBLE BIOSENSING PLATFORM FOR HIGH-THROUGHPUT MEASUREMENT OF CARDIOMYOCYTE CONTRACTILITY Wenkun Dou ¹ , Jason Maynes ² , and Yu Sun ¹ ¹ University of Toronto, CANADA and ² Hospital for Sick Children, CANADA	. 2 9
12:05	FLEXIBLE BI-DIRECTIONAL BRAIN COMPUTER INTERFACE FOR CONTROLLING TURNING BEHAVIOR OF MICE Yifei Ye ¹ , Ye Tian ^{1,2} , Han Wang ¹ , Qian Cheng ¹ , Kuikui Zhang ¹ , Xueying Wang ^{1,2} , Cunkai Zhou ¹ , Chengjian Xu ¹ , Xiaoling Wei ^{1,2} , Zhitao Zhou ^{1,2} , Tiger H. Tao ^{1,2,3,4,5,6} , and Liuyang Sun ^{1,2} ¹ Chinese Academy of Sciences, CHINA, ² University of Chinese Academy of Sciences, CHINA, ³ ShanghaiTech University, CHINA, ⁴ Neuroxess Co., Ltd. (Jiangxi), CHINA, ⁵ Guangdong Institute of Intelligence Science and Technology, CHINA, and ⁶ Tianqiao and Chrissy Chen Institute for Translational Research, CHINA	. 33
12:20	Lunch & Exhibit Inspection	
	Session III - MEMS Inertial Sensors and Power MEMS	
13:45	HIGH SENSITIVITY MEMS Z-AXIS ACCELEROMETER WITH IN-PLANE DIFFERENTIAL READOUT Valentina Zega ¹ , Gabriele Gattere ² , Manuel Riani ² , Francesco Rizzini ² , and Attilio Frangi ¹ Politecnico di Milano, ITALY and ² STMicroelectronics, ITALY	. 37
14:00	TWO-AXIS ELECTROMAGNETIC SCANNER INTEGRATED WITH AN ELECTROSTATIC XY-STAGE POSITIONER Yuki Okamoto, Hironao Okada, and Masaaki Ichiki National Institute of Advanced Industrial Science and Technology (AIST), JAPAN	. 41
14:15	MEMS SHOCK ABSORBERS INTEGRATED WITH AL ₂ O ₃ -REINFORCED, MECHANICALLY RESILIENT NANOTUBE ARRAYS Hojoon Lee ¹ , Eunhwan Jo ¹ , Jae-Ik Lee ² , and Jongbaeg Kim ¹ ¹ Yonsei University, KOREA and ² Harvard Medical School, USA	. 45

14:40	HIGH-INDUCTANCE-DENSITY MEMS 3D-SOLENOID TRANSFORMERS WITH INSERTED THIN-FILM FERRITE MAGNETIC CORE FOR ON-CHIP INTEGRATED DC-DC POWER CONVERSIONS Changnan Chen ^{1,2} , Pichao Pan ^{1,2} , Jiebin Gu ^{1,2} , and Xinxin Li ^{1,2} ¹ Chinese Academy of Sciences, CHINA and ² University of Chinese Academy of Sciences, CHINA	. 49
	Poster/Oral Session I	
14:45	Poster/Oral Session I Poster presentations are listed by topic category with their assigned number starting on Page 13.	
16:15	Break & Exhibit Inspection	
	MEMS Community Announcement	
16:45	Clark TC. Nguyen, University of California, Berkeley, USA	
	Session IV - BioMEMS II	
16:50	MICRON-SIZED PARYLENE-IN-OIL WATER PROTECTION LAYER	. 53
17:05	A PIPETTE TIP INTEGRATED WITH A CAPACITIVE MICROSENSOR FABRICATED BY COMBINED 3D PRINTING AND MEMS PROCESS FOR CELL DETECTION AND TRANSPORTATION	. 57
17:20	FOLDABLE POLYMER STENT INTEGRATED WITH WIRELESS PRESSURE SENSOR FOR BLOOD PRESSURE MONITORING Nomin-Erdene Oyunbaatar and Dong-Weon Lee Chonnam National University, KOREA	. 61
17:35	A DYNAMIC MICROARRAY DEVICE FOR SELECTIVE PAIRING AND ELECTROFUSION OF LIPOSOMES Sho Takamori ¹ , Hisatoshi Mimura ¹ , Toshihisa Osaki ¹ , and Shoji Takeuchi ^{1,2} ¹ Kanagawa Institute of Industrial Science and Technology, JAPAN and ² University of Tokyo, JAPAN	. 65
17:50	REAL-TIME FUNCTIONAL BRAIN MAPPING BASED ON HIGH-CHANNEL-COUNT, ULTRA-CONFORMAL NEURAL INTERFACE Xiner Wang ^{1,2} , Zhaohan Chen³, Jizhi Liang ^{1,2} , Xiaoling Wei¹,², Liuyang Sun¹,², Meng Li¹,², Zhitao Zhou¹,², and Tiger H. Tao¹,²,4,5,6 ¹ Chinese Academy of Sciences, CHINA, ² University of Chinese Academy of Science, CHINA, ³ Shanghai Normal University, CHINA, ⁴ Neuroxess Co., Ltd. (Jiangxi), CHINA, ⁵ Guangdong Institute of Intelligence Science and Technology, CHINA, and ⁶ Tianqiao and Chrissy Chen Institute for Translational Research, CHINA	. 67

Tuesday, 17 January All times are Central European Time (CET).

	Plenary Presentation II
08:30	ACOUSTOFLUIDICS: MERGING ACOUSTICS AND FLUID MECHANICS FOR BIOMEDICAL APPLICATIONS
	Session V - New Materials, Fabrication, and Packaging
09:15	SILICON CARBIDE REINFORCED VERTICALLY ALIGNED CARBON NANOTUBE COMPOSITE FOR HARSH ENVIRONMENT MEMS
09:30	A RELIABLE RELEASE METHOD FOR A BACK-END-OF-LINE NEMS SWITCH OF A MONOLITHIC THREE-DIMENSIONAL INTEGRATED CMOS-NEMS CIRCUIT
09:45	INCREASE OF EXPANSION RATE AND DIRECTION CONTROL OF MICROGEL ACTUATORS FOR SINGLE CELL MANIPULATIONS
10:00	GENERALIZED-ACCUMULATED-TEMPERATURE PARAMETER FOR CHARACTERISTIC PREDICTION OF METAL-BASED MEMS CANTILEVER
10:15	Break and Exhibit Inspection
	Session VI - Micro- and Nanofluidics and Medical Applications
10:45	MEMS-BASED WATER COLLECTION CONDENSATION PARTICLE COUNTER (WCCPC) OPTIMIZED FOR MULTI-POINT MONITORING OF AIRBORNE NANOPARTICLES
11:00	RECONSTITUTING FUNDAMENTALS OF BACTERIA MEDIATED CANCER THERAPY ON A CHIP
11:15	3D SPATIAL FOCAL CONTROL BY ARRAYED OPTOFLUIDIC PRISMS
11:30	HIGH-SPEED AND PINPOINT LIQUID EXCHANGE ON MICROFLUIDIC CHIP USING 3D PRINTED DOUBLE-BARRELED MICROPROBE WITH DUAL PUMPS

11:45	DESIGN OF A DNA SYNTHESIS CHIP FOR DATA STORAGE WITH ULTRA-HIGH THROUGHPUT AND DENSITY FEATURING LARGE-SCALE INTEGRATED CIRCUITS AND MICROFLUIDIC CONFINEMENT Ning Wang ^{1,2,3} , Shijia Yang ^{1,3} , Dayin Wang ^{1,2,3} , Zhen Cao ⁴ , Yuan Luo ^{1,3} , and Jianlong Zhao ^{1,3} ¹ Chinese Academy of Sciences, CHINA, ² ShanghaiTech University, CHINA, ³ University of Chinese Academy of Sciences, CHINA, and ⁴ Zhejiang University, CHINA	103
	MEMS 2024 Announcement	
12:00	MEMS 2024 Conference Chairs Wen Li, Michigan State University, USA Dana Weinstein, Purdue University, USA	
12:15	Lunch & Exhibit Inspection	
	Session VII - MEMS Fluidic Sensors	
13:15	A REAL-TIME WIRELESS CALORIMETRIC FLOW SENSOR SYSTEM WITH A WIDE LINEAR RANGE FOR LOW-COST RESPIRATORY MONITORING Lifeng Huang ¹ , Izhar ^{2,4} , Xiaoyong Zhou ³ , Mingdong Fang ³ , Siwei Huang ¹ , Yi-Kuen Lee ² , Xiaofang Pan ¹ , and Wei Xu ¹ ¹ Shenzhen University, CHINA, ² Hong Kong University of Science and Technology, CHINA, ³ Mindray Medical International Limited, CHINA, and ⁴ University of Pennsylvania, USA	107
13:30	ADVANCED THERMOPHYSICAL PROPERTIES MEASUREMENTS USING HEATER-INTEGRATED FLUIDIC RESONATORS Juhee Ko, Bong Jae Lee, and Jungchul Lee Korea Advanced Institute of Science and Technology (KAIST), KOREA	111
13:45	A MINIATURIZED TRANSIT-TIME ULTRASONIC FLOWMETER USING PMUTS FOR LOW-FLOW MEASUREMENT IN SMALL-DIAMETER CHANNELS	115
14:00	MEMS DIFFERENTIAL THERMOPILES FOR HIGHLY-SENSITIVE HYDROGEN GAS DETECTION Haozhi Zhang ^{1,2} , Hao Jia ^{1,2} , Ming Li ^{1,2} , Pengcheng Xu ^{1,2} , and Xinxin Li ^{1,2} ¹ Chinese Academy of Sciences, CHINA and ² University of Chinese Academy of Sciences, CHINA	119
	Poster/Oral Session II	
14:15	Poster/Oral Session II Poster presentations are listed by topic category with their assigned number starting on Page 13.	
15:45	Break & Exhibit Inspection	
	Session VIII - Sonics & Ultrasonics MEMS	
16:15	DOMAIN/BOUNDARY VARIATION IN CANTILEVER ARRAY FOR BANDWIDTH ENHANCEMENT OF PZT MEMS MICROSPEAKER	123

19:00 - 22:00	Banquet at the Löwenbräu Keller	
17:30	Adjourn for the day	
17:15	EPITAXIAL PB(ZR,T1)O3-BASED PIEZOELECTRIC MICROMACHINED ULTRASONIC TRANSDUCER FABRICATED ON SILICON-ON-NOTHING (SON) STRUCTURE	139
17:00	HIGH-SPL AND LOW-DRIVING-VOLTAGE PMUTS BY SPUTTERED POTASSIUM SODIUM NIOBATE Fan Xia ^{1,2} , Yande Peng ^{1,2} , Sedat Pala ^{1,2} , Ryuichi Arakawa ^{1,3} , Wei Yue ^{1,2} , Pei-Chi Tsao ² , Chun-Ming Chen ² , Hanxiao Liu ^{1,2} , Megan Teng ² , Jong Ha Park ^{1,2} , and Liwei Lin ^{1,2} ¹ Berkeley Sensor and Actuator Center, USA, ² University of California, Berkeley, USA, and ³ NGK Spark Plug Co., JAPAN	135
16:45	HIGH-PERFORMANCE WAFER-SCALE TRANSFER-FREE GRAPHENE MICROPHONES Roberto Pezone, Gabriele Baglioni, Pasqualina M. Sarro, Peter G. Steeneken, and Sten Vollebregt Delft University of Technology, NETHERLANDS	131
16:30	ON THE DESIGN OF PIEZOELECTRIC MEMS MICROSPEAKER WITH HIGH FIDELITY AND WIDE BANDWIDTH Ting-Chou Wei, Zih-Song Hu, Shu-Wei Chang, and Weileun Fang National Tsing Hua University, TAIWAN	127

Wednesday, 18 January All times are Central European Time (CET).

	Plenary Presentation III	
08:30	LEVERAGING SEMICONDUCTOR ECOSYSTEMS TO MEMS	143
	Session IX - Optomechanics & Photonics Integration	
09:15	PROGRAMMABLE SILICON NITRIDE PHOTONIC INTEGRATED CIRCUITS	149
09:30	MULTIFREQUENCY NANOMECHANICAL MASS SPECTROMETER PROTOTYPE FOR MEASURING VIRAL PARTICLES USING OPTOMECHANICAL DISK RESONATORS	
09:45	A MICROFABRICATED DIAMOND QUANTUM MAGNETOMETER WITH PICOTESLA SCALE SENSITIVITY Fei Xie ^{1,2} , Qihui Liu ^{1,2} , Yuqiang Hu ^{3,4} , Lingyun Li ^{1,2} , Zhichao Chen ^{1,2} , Jin Zhang ¹ , Yonggui Zhang ^{1,2} , Yuyao Zhang ^{3,4} , Yang Wang ^{1,2} , Jiangong Cheng ^{1,2} , Hao Chen ^{1,2} , and Zhenyu Wu ^{1,2,3,4} ¹ Chinese Academy of Sciences, CHINA, ² University of Chinese Academy of Sciences, CHINA, ³ Shanghai University, CHINA, and ⁴ Shanghai Industrial μTechnology Research Institute, CHINA	157
10:00	Break & Exhibit Inspection	
	Session X - RF MEMS Filters & Resonators (5G & 6G)	
10:30	A NON-VOLATILE THRESHOLD SENSING SYSTEM USING A FERROELECTRIC HF _{0.5} ZR _{0.5} O ₂ DEVICE AND A L _I N _b O ₃ MICROACOUSTIC RESONATOR Onurcan Kaya, Luca Colombo, Benyamin Davaji, and Cristian Cassella Northeastern University, USA	161
10:45	RESONANT CONFINERS FOR ACOUSTIC LOSS MITIGATION IN BULK ACOUSTIC WAVE RESONATORS Jeronimo Segovia-Fernandez and Ernest TT. Yen Texas Instruments, Kilby Labs, USA	165
11:00	HIGH-CRYSTALLINITY 30% SCALN ENABLING HIGH FIGURE OF MERIT X-BAND MICROACOUSTIC RESONATORS FOR MID-BAND 6G	169

11:15	FERRITE-ROD ANTENNA DRIVEN WIRELESS RESOSWITCH RECEIVER
11:30	ULTRA-WIDEBAND MEMS FILTERS USING LOCALIZED THINNED 128° Y-CUT THIN-FILM LITHIUM NIOBATE
11:45	Lunch & Exhibit Inspection
	Session XIa - MEMS/NEMS Resonators & Non-Linear Dynamics
13:00	ATTRACTOR EXCHANGER FOR OPEN-LOOP OPERATION OF MICROMECHANICAL NONLINEAR RESONATORS USING GAP-SPACING CONTINUATION
13:15	A CMOS-MEMS ULTRASENSITIVE THERMOMETER USING INTERNAL RESONANCE INDUCED FREQUENCY COMBS
13:30	ATOMICALLY THIN NEMS FREQUENCY COMB WITH BOTH FREQUENCY TUNABILITY AND RECONFIGURABLE VIA SIMULTANEOUS 1:2 AND 1:3 MODE COUPLING
13:45	INSTRUMENTAL ANALYSIS OF ADVANCED CATALYSTS BASED ON RESONANT MICROCANTILEVERS Xinyu Li ^{1,2} , Pengcheng Xu ^{1,2} , Ying Chen ¹ , Haitao Yu ¹ , and Xinxin Li ^{1,2} Chinese Academy of Sciences, CHINA and ² University of Chinese Academy of Sciences, CHINA
	Session XIb - BioSensors I
13:00	A MULTIPLEXED BIOAFFINITY BIOSENSING PATCH FOR POINT-OF-CARE CHRONIC ULCER MONITORING
13:15	3-DOF BIOHYBRID ACTUATOR WITH MULTIPLE SKELETAL MUSCLE TISSUES
13:30	A LOW NOISE MICROELECTRODE ARRAY FOR SPECIFIC CELL ACTIVITY MODULATION FROM CELL TO TISSUE

13:45	BIONIC MECHANICAL HAND INTEGRATED WITH ARTIFICIAL OLFACTORY SENSOR ARRAY FOR ENHANCED OBJECT RECOGNITION Jiachuang Wang ^{1,2} , Xiaohui Li ^{1,2} , MengWei Liu ^{1,2} , Pingping Zhang ³ , Tiger H. Tao ^{1,2,4} , and Nan Qin ^{1,2}	. 209
	¹ Chinese Academy of Sciences, CHINA, ² University of Chinese Academy of Sciences, CHINA, ³ Suzhou Huiwen Nanotechnology Co., Ltd., CHINA, and ⁴ Neuroxess Co., Ltd. (Jiangxi), CHINA	
	Poster/Oral Session III	
14:00	Poster/Oral Session III Poster presentations are listed by topic category with their assigned number starting on Page 13.	
15:30	Break & Exhibit Inspection	
S	ession XIIa - Force & Displacement/ Tactile Sensors & Human-Machine	2
16:00	HIGH RESOLUTION TACTILE SENSOR FOR MEASUREMENT OF A COMPLICATED TACTILE FEELING OF "SHITTORI" WITH MOISTNESS	. 213
16:15	PYRAMIDAL STRUCTURED MXENE/ECOFLEX COMPOSITE-BASED TOROIDAL TRIBOELECTRIC SELF-POWERED SENSOR FOR HUMAN-MACHINE INTERFACE Shipeng Zhang, Sm Sohel Rana, Gagan Bahad Pradhan, Trilochan Bhatta, Seonghoon Jeong, and Jae Yeong Park Kangwoon University, KOREA	. 217
16:30	LIG-BASED TRIAXIAL TACTILE SENSOR UTILIZING ROTATIONAL ERECTION SYSTEM Rihachiro Nakashima ¹ , Nagi Nakamura ² , Tomohiko G. Sano ¹ , Eiji Iwase ² , and Hidetoshi Takahashi ¹ **Ikeio University, JAPAN and **2 Waseda University, JAPAN	. 221
16:45	A STRETCHABLE STRAIN-INSENSITIVE SMART GLOVE FOR SIMULTANEOUS DETECTION OF PRESSURE AND TEMPERATURE	. 225
17:00	A GESTURE RECOGNITION GLOVE ASSEMBLED WITH NANOFOREST-INTEGRATED INFRARED THERMOPILES Mao Li ^{1,2} , Meng Shi ^{1,2} , Guidong Chen ^{1,2} , Na Zhou ^{1,2} , Haiyang Mao ^{1,2} , and Chengjun Huang ^{1,2} ¹ Chinese Academy of Sciences, CHINA and ² University of Chinese Academy of Sciences, CHINA	. 229
	Session XIIb - BioSensors II	
16:00	ONE PUSH MEMBRANE FORMATION FOR ITERATIVE MEASUREMENT OF ION CHANNEL ACTIVITY ON ARRAYED CHIP Hisatoshi Mimura ¹ , Toshihisa Osaki ^{1,2} , Sho Takamori ¹ , Kenji Nakao ² , and Shoji Takeuchi ^{1,3} ¹ Kanagawa Institute of Industrial Science and Technology (KISTEC), JAPAN, ² Maqsys Inc., JAPAN, and ³ University of Tokyo, JAPAN	. 233
16:15	AN IMPLANTABLE DIFFERENTIAL SENSOR WITH PASSIVE WIRELESS INTERROGATION FOR IN-SITU EARLY DETECTION OF PERIPROSTHETIC JOINT INFECTION Jiaxin Jiang, Cole Napier, Chandrashekhar Choudhary, H. Claude Sagi, Chia-Ying Lin, Michael T. Archdeacon, and Tao Li University of Cincinnati, USA	. 235

16:30	MICROMACHINED PIEZOELECTRIC FILM-BASED FLEXIBLE ELECTRONICS WITH INTEGRATION OF FILM-SELF TEMPERATURE-DETECTING BREATH SENSOR AND ACETONE GAS SENSOR	239
	Hung-Yu Yeh and Guo-Hua Feng National Tsing Hua University, TAIWAN	
16:45	FLEXIBLE TACTILE SENSING ARRAY WITH HIGH SPACIAL DENSITY BASED ON PARYLENE MEMS TECHNIQUE Meixuan Zhang ¹ , Zetian Wang ¹ , Han Xu ² , Lang Chen ¹ , Yufeng Jin ^{2,3} , and Wei Wang ^{1,3,4}	243
	¹ Peking University, CHINA, ² Peking University Shenzhen Graduate School, CHINA, ³ National Key Lab of Micro/Nano Fabrication Technology, CHINA, and ⁴ Beijing Advanced Innovation Center for Integrated Circuits, CHINA	
17:00	SILK-ENABLED FOLDABLE AND CONFORMAL NEURAL INTERFACE WITH IN-PLANE SHIELDING FOR HIGH-QUALITY ELECTROPHYSIOLOGICAL RECORDINGS	
17:15	Adjourn for the day	

Thursday, 19 January All times are Central European Time (CET).

	Plenary Presentation IV	
08:30	MATERIALS ENGINEERING FOR CHEMICAL SENSING ENHANCEMENT	251
	Session XIII - Gas & Flow Sensors	
09:15	ON-DEMAND PREPARATION OF GAS-SENSING MATERIALS GUIDED BY RESONANT CANTILEVER-BASED THERMOGRAVIMETRIC ANALYSIS	255
09:30	AN INTELLIGENT GAS ANALYSIS SYSTEM CONSISTING OF SENSORS AND A NEURAL NETWORK IMPLEMENTED USING THIN-FILM TRANSISTORS	!59
09:45	SINGLE-LAYER-ELECTRODE TEMPERATURE-MODULATED SNO ₂ GAS SENSOR CELL WITH LOW POWER CONSUMPTION FOR DISCRIMINATION OF FOOD ODORS	163
10:00	A PERFORMANCE ENHANCED THERMAL FLOW SENSOR WITH NOVEL DUAL-HEATER STRUCTURE USING CMOS COMPATIBLE FABRICATION PROCESS	
	Session XIV - New Fabrication Techniques	
10:45	LOCAL METAL DEPOSITION ON HYDROGELS USING MICRO-PLASMA-BUBBLES 2 Haruna Takahashi, Yu Yamashita, Naotomo Tottori, Shinya Sakuma, and Yoko Yamanishi Kyushu University, JAPAN	!71
11:00	FOLDING METHOD OF KIRIGAMI STRUCTURE WITH FOLDING LINES	275
11:15	BUBBLE-ASSISTED RE-FORMATION OF INDIVIDUAL LIPID BILAYERS IN ARRAYED DEVICE	! 79

11:30	LARGE-SCALE ARRAYS OF TUNABLE MONOLAYER	
	MoS2 NANOELECTROMECHANICAL RESONATORS	281
	Zuheng Liu ¹ , Luming Wang ³ , Pengcheng Zhang ¹ , Maosong Xie ¹ ,	
	Yueyang Jia ¹ , Ying Chen ⁴ , Hao Jia ⁴ , Zenghui Wang ³ , and Rui Yang ^{1,2}	
	¹ University of Michigan – Shanghai Jiao Tong University Joint Institute, Shanghai Jiao Tong University,	,
	CHINA, ² Shanghai Jiao Tong University, CHINA, ³ University of Electronic Science and Technology of	
	China. CHINA. and ⁴ Chinese Academy of Sciences. CHINA	

Awards Ceremony

11:45	Awards Ceremon	V
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11:55 Final Remarks

12:00 Conference Ajourns

POSTER PRESENTATIONS

All times are Central European Time (CET).

M - Monday, 16 January - 13:45 - 15:45

T - Tuesday, 17 January - 13:30 - 15:30

W - Wednesday, 18 January - 13:30 - 15:30

Classification Chart

(last character of poster number)

_	_ 1	D:	 	.1	N /T		1: .	1	T.	/	7	/	C
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- b Emerging Technologies and New Opportunities for MEMS/NEMS
- c Industry MEMS and Advancing MEMS for Products and Sustainability
- d Materials, Fabrication and Packaging for Generic MEMS and NEMS
- e MEMS Actuators and PowerMEMS
- f MEMS Physical and Chemical Sensors
- g Micro- and Nanofluidics
- h Optical, RF and Electromagnetics for MEMS/NEMS
- i Open Posters

a - Bio and Medical MEMS Biosensors and Bioreactors 01-a ANTIFOULING FOR ELECTROCHEMICALLY BIOSENSING IN BOD

M01-a	ANTIFOULING FOR ELECTROCHEMICALLY BIOSENSING IN BODY FLUIDS	285
T01-a	ELECTRO-MAGNETIC SENSOR MEDIATED BY MAGNETIC BIOMOLECULES	289
W01-a	GAS-FLOW DEVICE FOR EFFECTIVE DISSOLUTION OF GAS-PHASE ODORANTS UTILIZED FOR BIOHYBRID SENSORS	293
M02-a	MULTIPLE WELLS ON A CMOS-MEA FOR CELL-BASED BIOHYBRID ODORANT SENSORS Yujia Lian, Haruka Oda, Minghao Nie, and Shoji Takeuchi University of Tokyo, JAPAN	295

	MICROELECTRODES TOWARDS LONG-TERM NEUROPHYSIOLOGICAL SIGNALING AND DOPAMINE SENSITIVE DETECTION	Tecl
	a - Bio and Medical MEMS	
	Devices & Systems for Cellular and Molecular Studies	
W02-a	COMPARISON OF SELECTIVE FILTRATION OF ON-CHIP GLOMERULUS COMPRISED OF ORGANOID-DERIVED AND IMMORTALIZED PODOCYTES	301
М03-а	CONTROLLING FIRING POINT OF MICROFIBER-SHAPED HIPSC-DERIVED CARDIAC TISSUE WITH LOCALIZED ELECTRICAL STIMULATION DEVICE	305
Т03-а	DEVELOPMENTAL PHASES OF ON-CHIP VASCULOGENESIS CLASSIFIED USING A DEEP LEARNING VISUAL MODEL Taiga Irisa, Hang Zhou, Kazuya Fujimoto, and Ryuji Yokokawa Kyoto University, JAPAN	309
W03-a	HAND-DRIVEN DEVICE FOR PREPARATION OF LINEARLY ALIGNED HYDROGEL SHEETS Aoi Kato ^{1,2} , Haruka Oda ³ , Sho Takamori ² , Hisatoshi Mimura ² , Toshihisa Osaki ² , Norihisa Miki ^{1,2} , and Shoji Takeuchi ^{2,3} ¹ Keio University, JAPAN, ² Kanagawa Institute of Industrial Science and Technology, JAPAN, and ³ University of Tokyo, JAPAN	313
M04-a	MICROFABRICATION AND CHARACTERIZATION OF MICRO- STEREOLITHOGRAPHICALLY 3D PRINTED, AND DOUBLE METALLIZED BIOPLATES WITH 3D MICROELECTRODE ARRAYS FOR IN-VITRO ANALYSIS OF CARDIAC ORGANOIDS Jorge Manrique Castro, Isaac Johnson, and Swaminathan Rajaraman University of Central Florida, USA	315
Т04-а	OIL-SEALED RGD-MODIFIED HYDROGEL MICROWELL ARRAY WITH SIZE-SELECTIVE PERMEATION FOR ANALYSIS ON EXOSOMES FROM SINGLE CELLS Chisaki Yamagata ¹ , Shun Itai ¹ , Yuta Kurashina ² , Makoto Asai ¹ , Ayuko Hoshino ³ , and Hiroaki Onoe ¹ ¹ Keio University, JAPAN, ² Tokyo University of Agriculture and Technology, JAPAN, and ³ Tokyo Institute of Technology, JAPAN	319
W04-a	PICKING SINGEL CELLS FROM 10 ML SAMPLE BASED ON A MICROFILTRATION- LIFT COMBINATION PLATFORM Qingmei Xu ¹ , Yuntong Wang ^{2,3} , Xiao Ma ⁴ , Hang Li ⁵ , Ying Xue ⁵ , Yi Zhang ¹ , Songtao Dou ¹ , Huan Wang ² , Bei Li ^{2,5} , and Wei Wang ^{1,6,7} ¹ Peking University, CHINA, ² Chinese Academy of Sciences, CHINA, ³ University of Chinese Academy of Sciences, CHINA, ⁴ Hangzhou Branemagic Medical Technology Co. Ltd., CHINA, ⁵ Hooke Laboratory, CHINA, ⁶ National Key Lab of Micro/Nano Fabrication Technology, CHINA, and ⁷ Beijing Advanced Innovation Center for Integrated Circuits, Beijing, CHINA	323

TO2-a THE INTEGRATED RGO/PEDOT: PSS-MODIFIED ULTRAFLEXIBLE

a - Bio and Medical MEMS

Flexible and Wearable Devices and Systems

M05-a	A TRANSFER METHOD FOR EMBEDDING CONDUCTIVE FILLERS ON THE SURFACE OF MULTI-SCALE STRUCTURES FOR 3D FLEXIBLE CONDUCTORS	327
Т05-а	FABRICATION OF HIGH FREQUENCY 2D FLEXIBLE PMUT ARRAY	331
W05-a	FLEXIBLE SILK-BASED GRAPHENE BIOELECTRONICS FOR WEARABLE MULTIMODAL PHYSIOLOGICAL MONITORING Sajjad Mirbakht ¹ , Ata Golparvar ^{1,2} , Muhammad Umar ¹ , and Murat Kaya Yapici ^{1,3} ¹ Sabanci University, TURKEY, ² École Polytechnique Fédérale de Lausanne (EPFL), SWITZERLAND, a ³ University of Washington, USA	
M06-a	HIGHLY ACCURATE MEASUREMENT OF CONTACT RESISTANCE BETWEEN GALINSTAN AND COPPER USING TRANSFER LENGTH METHOD Takashi Sato and Eiji Iwase Waseda University, JAPAN	339
Т06-а	MACHINE LEARNING ENABLED HIND FOOT DEFORMITY DETECTION USING INDIVIDUALLY ADDRESSABLE HYBRID PRESSURE SENSOR MATRIX	343
W06-a	MULTI-MODE E-SKIN INTEGRATING CAPACITIVE-PIEZOELECTRIC SENSORS FOR STATIC-DYNAMIC MECHANORESPONSE WITH WIDE SENSING RANGE	347
M07-a	NON-INVASIVE INSTANT MEASUREMENT OF ARTERIAL STIFFNESS BASED ON HIGH-DENSITY FLEXIBLE SENSOR ARRAY Fang Wang ^{1,2} , Heng Yang ^{1,2} , Ke Sun ¹ , Yi Sun ¹ , and Xinxin Li ^{1,2} ¹ Chinese Academy of Sciences, CHINA and ² University of Chinese Academy of Sciences, CHINA	351
Т07-а	SUPPRESSION OF BIOELECTRICAL NOISE SIGNALS IN MOTION STATE BY LOW-COST MICROPILLAR HYDROGEL ELECTRODE Gencai Shen, Nan Zhao, Chunpeng Jiang, Zhuangzhuang Wang, and Jingquan Liu Shanghai Jiao Tong University, CHINA	355
W07-a	ULTRA-THIN MEMS PACKAGING BASED ON AUXETIC STRETCHABLE STRUCTURES FOR APPLICATIONS IN WEARABLE ELECTRONICS	359
M08-a	ULTRALOW POWER FLEXIBLE OCULAR MICROSYSTEM FOR VERGENCE AND DISTANCE SENSING BASED ON PASSIVE DIFFERENTIAL MAGNETOMETRY	362

a - Bio and Medical MEMS Manufacturing for Bio- & Medical MEMS

T08-a	ELECTROHYDRODYNAMIC NEBULISER (eNEB) FOR DIRECT PULMONARY DRUG DELIVERY APPLICATION Trung-Hieu Vu¹, Luan Ngoc Mai².³, Tuan-Hung Nguyen¹, Dang Tran¹, Tuan-Khoa Nguyen¹, Thanh Nguyen⁴, Jarred Fastier-Woollel¹.⁵, Canh-Dung Tran⁴, Toan Dinh⁴, Hong-Quan Nguyen¹, Dzung Viet Dao¹, and Van Thanh Dau¹ ¹Griffith University, AUSTRALIA, ²Ho Chi Minh City University of Technology (HCMUT), VIETNAM ³Vietnam National University, VIETNAM, ⁴University of Southern Queensland, AUSTRALIA, and ⁵University of Tokyo, JAPAN	. 366
W08-a	FLEXIBLE POLYMER OPTICAL WAVEGUIDES FOR INTEGRATED OPTOGENETIC BRAIN IMPLANTS Julian A. Singer ¹ , Till Stramm ² , Jens Fasel ² , Oliver Schween ² , Anton Gelaeschus ¹ , Andreas Bahr ^{1,3} , and Matthias Kuhl ⁴ ¹ Hamburg University of Technology, GERMANY, ² TU Dortmund University, GERMANY, ³ University of Kiel, GERMANY, and ⁴ University of Freiburg, GERMANY	. 370
M09-a	HIGHLY REPRODUCIBLE TISSUE POSITIONING WITH TAPERED PILLAR DESIGN IN ENGINEERED HEART TISSUE PLATFORMS Milica Dostanic ^{1,2} , Laura M. Windt ² , Maury Wiendels ² , Berend J. van Meer ² , Christine L. Mummery ^{2,3} , Pasqualina M. Sarro ¹ , and Massimo Mastrangeli ¹ ¹ Delft University of Technology, NETHERLANDS, ² Leiden University Medical Center, NETHERLANDS ³ University of Twente, NETHERLANDS	
Т09-а	IN VITRO ASSEMBLY OF MUSCLE RINGS AND BIOPRINTED HYDROGEL FOR BRANCHING TUBULAR TISSUE CONSTRUCTS Tomohiro Morita, Byeongwook Jo, Minghao Nie, and Shoji Takeuchi University of Tokyo, JAPAN	. 378
W09-a	MICROELECTRODES FABRICATED BY VACUUM FILLING WITH LOW MELTING-POINT ALLOY FOR MUSCLE TISSUE STIMULATION Tingyu Li, Minghao Nie, Yuya Morimoto, and Shoji Takeuchi University of Tokyo, JAPAN	. 381
M10-a	OPTOELECTRONIC INTEGRATED ULTRAMICROELECTRODE FOR OPTICAL STIMULATION AND ELECTRICAL RECORDING OF SINGLE-CELL	. 384
T10-a	THERMOFORMING OF PARYLENE C TO FORM HELICAL STRUCTURES	. 388
	a - Bio and Medical MEMS	
	Materials for Bio- and Medical MEMS	
W10-a	FABRICATION OF BIODEGRADABLE SOFT TISSUE-MIMICKED MICROELECTRODE ARRAYS FOR IMPLANTED NEURAL INTERFACING	. 392

a - Bio and Medical MEMS

Medical Microsystems

M11-a	AN OPTIMIZATION OF PERFORATION DESIGN ON A PIEZOELECTRIC-BASED SMART STENT FOR BLOOD PRESSURE MONITORING AND LOW-FREQUENCY VIBRATIONAL ENERGY HARVESTING	396
W11-a	DEVELOPMENT OF AN ELECTRICAL-STIMULATION-INDUCED MECHANOMYOGRAM PROBE FOR MUSCLE CONTRACTION CHARACTERISTICS EVALUATION	400
M12-a	DUAL-FREQUENCY PIEZOELECTRIC MICROMACHINED ULTRASONIC TRANSDUCERS FOR FUNDAMENTAL AND HARMONIC IMAGING Yanfen Zhai, Waleed Maqsood, Zhou Da, Nikolai Andrianov, Yucheng Zhang, Mohssen Moridi, and Lixiang Wu Silicon Austria Labs GmbH, AUSTRIA	402
T12-a	FRACTAL MICROELECTRODES INTEGRATED WITH THE CATHETER FOR LOW-VOLTAGE PULSED FIELD ABLATION	405
W12-a	HIERARCHICAL BONDING YIELD TEST STRUCTURE FOR FLEXIBLE HIGH CHANNEL-COUNT NEURAL PROBES INTERFACING ASIC CHIPS Marie C. Odenthal, Victor Claar, Oliver Paul, and Patrick Ruther University of Freiburg, GERMANY	409
M13-a	MICROWAVE-INDUCED THERMOACOUSTIC IMAGING USING ALUMINUM NITRIDE PMUT Yiwei Wang¹, Lejia Zhang¹, Junxiang Cai¹,2,3, Baosheng Wang¹,2,3, Yuandong Alex Gu⁵, Liang Lou⁵, Xiong Wang¹,2,3,4, and Tao Wu¹,2,3,4 ¹ShanghaiTech University, CHINA and ²Chinese Academy of Sciences, CHINA, ³University of Chinese Academy of Sciences, CHINA, ⁴Shanghai Engineering Research Center of Energy Efficient and Custom AIC, CHINA, and ⁵Shanghai Industrial μTechnology Research Institute, CHINA	
T13-a	NEEDLE-FREE DRUG INJECTION USING A SHOCK WAVE FOCUSING SYSTEM WITH THE FUNCTION OF REAL-TIME MICROBUBBLE-BASED DISTANCE SENSING	417
W13-a	NEW WAFER-LEVEL FABRICATION OF ULTRATHIN SILICON INSERTION SHUTTLES FOR FLEXIBLE NEURAL IMPLANTS	421
M14-a	REAL-TIME DYNAMIC LACTATE DETECTION IN A PIPELINE USING A MICROSENSING NEEDLE FOR ICU PATIENT MONITORING APPLICATION Yuan-Sin Tang¹, Tung-Lin Yang², Yu-Ting Cheng¹, Hsiao-En Tsai², and Yih-Shurng Chen³, ¹National Yang Ming Chiao Tung University, TAIWAN, ²National Taiwan Hospital HsinChu Branch, TAIWAN, ³National Taiwan University College of Medicine Graduate Institute of Clinical Medicine, TAIWAN, and ⁴National Taiwan University Hospital, TAIWAN	425

T14-a	THREE-DIMENSIONAL FLEXIBLE NEURAL OPTO-ELECTRONIC ARRAY WITH SILK-BASED SHUTTLE-FREE IMPLANTATION
	a - Bio and Medical MEMS
	MEMS & BioMEMS for Fighting COVID-19 & Future Pandemic
W14-a	A MICROFLUIDIC BIOSENSOR FOR RAPID DETECTION OF COVID-19
M15-a	A LOOP-MEDIATED ISOTHERMAL AMPLIFICATION (LAMP)-BASED POINT-OF-CARE SYSTEM FOR RAPID ON-SITE CLINICAL DETECTION OF SARS-COV-2 VIRUSES
	a - Bio and Medical MEMS
	MEMS & BioMEMS for Healthcare and Public Health
Т15-а	A SOLAR-DRIVEN WEARABLE MULTIPLEXED BIO-SENSING SYSTEM FOR NONINVASIVE HEALTHCARE MONITORING IN SWEAT
W15-a	HIGH-THROUGHPUT MASS MEASUREMENT OF SINGLE BACTERIAL CELLS BY SILICON NITRIDE MEMBRANE RESONATORS
M16-a	MICROFABRICATED ISOTHERMAL EG-FET SENSOR FOR LAMP MEDIATED CRISPR/CAS12A DETECTION OF HEPATITIS C VIRUS
T16-a	SMART ELECTRODE ARRAY FOR COCHLEAR IMPLANTS

	Tissue Engineering	
W16-a	A THREE-DIMENSIONAL ARTIFICIAL INTESTINAL TISSUE WITH A CRYPT-LIKE INNER SURFACE Shuma Tanaka ¹ , Shun Itai ² , and Hiroaki Onoe ¹ ¹ Keio University, JAPAN and ² Tohoku University, JAPAN	456
M17-a	TISSUE-ENGINEERED PENNATE MUSCLES ON A CHIP Motoki Ito, Yuya Morimoto, and Shoji Takeuchi University of Tokyo, JAPAN	460
T17-a	WEIGHT TRAINING DEVICE TO PROMOTE MATURATION IN SKELETAL MUSCLE TISSUES Kentaro Motoi, Byeongwook Jo, Yuya Morimoto, and Shoji Takeuchi University of Tokyo, JAPAN	463
	a - Bio and Medical MEMS	
	Other Bio and Medical MEMS	
W17-a	MICROSYSTEM VIBRATING MESH ATOMIZER WITH INTEGRATED MICROHEATER FOR HIGH VISCOSITY LIQUID AEROSOL GENERATION Pallavi Sharma, Irma Rocio Vazquez, and Nathan Jackson University of New Mexico, USA	467
M18-a	SCALABLE MODULAR MEASUREMENT SYSTEM FOR CONTINUOUS BLOOD MONITORING WITH PIEZOELECTRIC MEMS RESONATORS Michael Schneider ¹ , Bernhard Kößl ¹ , Suresh Alasatri ¹ , Ingrid A.M. Magnet ² , and Ulrich Schmid ¹ TU Wien, AUSTRIA and ² Medical University of Vienna, AUSTRIA	471
T18-a	SILICON COMPATIBLE PROCESS TO INTEGRATE IMPEDANCE CYTOMETRY WITH MECHANICAL CHARACTERIZATION	475
W18-a	SORTING OF EXTRACELLULAR VESICLES BY USING OPTICALLY-INDUCED DIELECTROPHORESIS ON AN INTEGRATED MICROFLUIDIC CHIP	479
	b - Emerging Technologies and New Opportunities for MEMS/NEMS	
	Internet of Things (IoT) with MEMS/NEMS	
M19-b	A REPROGRAMMABLE MEM SWITCH UTILIZING CONTROLLED CONTACT WELDING Tsegereda K. Esatu, Hei Kam, Lars P. Tatum, Xiaoer Hu, Urmita Sikder, Sergio Almeida, Junqiao Wu, and Tsu-Jae King Liu University of California, Berkeley, USA	483
T19-b	MICROMECHANICAL RSSI BASED ON FORCE INTERACTION DERIVED TAPPING BANDWIDTH VARIATION IN VIBRO-IMPACT RESONATORS	487

a - Bio and Medical MEMS

W19-b	WAKE-UP IOT WIRELESS SENSING NODE BASED ON A LOW-G THRESHOLD MEMS INERTIAL SWITCH WITH RELIABLE CONTACTS Sagnik Ghosh ¹ , Duan Jian Goh ¹ , Yul Koh ¹ , Jaibir Sharma ¹ , Wei Da Toh ¹ , Weiguo Chen ¹ , Yao Zhang ¹ , Eldwin Ng ¹ , Amit Lal ² , and Joshua EY. Lee ¹ Agency for Science, Technology and Research (A*STAR), SINGAPORE and ² Cornell University, USA	491
	b - Emerging Technologies and New Opportunities for MEMS/NEMS	
	Machine Learning (ML) & Artificial Intelligence (AI) Enhanced MEMS/NEMS Design, Manufacturing, and Applications	
M20-b	ARTIFICIAL INTELLIGENCE (AI)-ENHANCED E-SKIN WITH ARTIFICIAL SYNAPSE SENSORY OUTPUT FOR HUMANOID ROBOTIC FINGER OF MULTIMODAL PERCEPTION	495
Т20-ь	MULTI-MEMS DIFFERENTIAL PRESSURE SENSOR ELEMENTS-BASED AIRFLOW SENSOR WITH NEURAL NETWORK MODEL Kotaro Haneda, Kenei Matsudaira, and Hidetoshi Takahashi Keio University, JAPAN	499
W20-b	TRIAL-AND-ERROR LEARNING FOR MEMS STRUCTURAL DESIGN ENABLED BY DEEP REINFORCEMENT LEARNING	503
	b - Emerging Technologies and New Opportunities for MEMS/NEMS	
	New Computing Devices and Systems with MEMS/NEMS	
M21-b	FULLY MICROELECTROMECHANICAL NON-VOLATILE MEMORY CELL Elliott Worsey, Mukesh K. Kulsreshath, Qi Tang, and Dinesh Pamunuwa University of Bristol, UK	507
T21-b	NONVOLATILE STATE CONFIGURATION OF NANO-WATT PARAMETRIC ISING SPINS THROUGH FERROELECTRIC HAFNIUM ZIRCONIUM OXIDE MEMS VARACTORS	511
W21-b	PHYSICAL RESERVOIR COMPUTING USING NONLINEAR MEMS RESONATOR HAVING HIGH MEMORY CAPACITY AT "EDGE OF CHAOS" Hiroki Takemura, Takahiro Mizumoto, Amit Banerjee, Jun Hirotani, and Toshiyuki Tsuchiya Kyoto University, JAPAN	515
M22-b	PROGRAMMABLE FERROELECTRIC HZO NEMS MECHANICAL MULTIPLIER FOR IN-MEMORY COMPUTING Shubham Jadhav, Ved Gund, and Amit Lal Cornell University, USA	519
T22-b	STORING MEMS INTERFACES WITHOUT ELECTRICAL AUXILIARY ENERGY FOR LONG-TIME MONITORING Martin Hoffmann ¹ , Philip Schmitt ¹ , Steffen Wittemeier ³ , Falk Schaller ² , Alexey Shaporin ³ , Chris Stöckel ^{2,3} , Volker Geneiß ³ , Roman Forke ³ , Christian Hedayat ³ , Ulrich Hilleringmann ⁴ , Harald Kuhn ^{2,3} , and Sven Zimmermann ^{2,3} ¹ Ruhr-Universität Bochum, GERMANY, ² Chemnitz University of Technology, GERMANY, ³ Fraunhofer Institute for Electronic Nano Systems ENAS, GERMANY, and ⁴ University of Paderborn, GERMANY	522

	Nonlinear Dynamics in MEMS/NEMS	
W22-b	A NEW FINDING ON NONLINEAR DAMPING AND STIFFNESS OF FLEXURAL MODE CAPACITIVE MEMS RESONATORS Hung-Yu Chen, Ming-Huang Li, and Sheng-Shian Li National Tsing Hua University, TAIWAN	526
M23-b	EXPLOITING PARAMETRIC INSTABILITY IN BISTABLE MEMS ACTUATORS	
Т23-ь	FIRST PROTOTYPE OF POLYMER MICROMACHINED FLAPPING WING NANO AIR VEHICLE Rashmikant, Ryotaro Suetsugu, Minato Onishi, and Daisuke Ishihara Kyushu Institute of Technology, JAPAN	534
W23-b	ITERATIVE LEARNING CONTROL FOR QUASI-STATIC MEMS MIRROR WITH SWITCHING OPERATION Matthias Macho ¹ , Han Woong Yoo ¹ , Richard Schroedter ² , and Georg Schitter ¹ ITU Wien, AUSTRIA and TU Dresden, GERMANY	538
	b - Emerging Technologies and New Opportunities for MEMS/NEMS	
	Quantum Devices and Systems with MEMS/NEMS	
M24-b	Mz ATOMIC MAGNETOMETER USING A 3D MEMS GLASS ALKALI VAPOR CELL WITH VERTICAL SIDEWALLS Jin Zhang, Jianfeng Zhang, Wenqi Li, Ziji Wang, and Jintang Shang Southeast University, CHINA	542
T24-b	ON-CHIP HEATING NOISE SUPPRESSION OF 3D CHIP-SCALE ATOMIC MAGNETOMETER USING SINGLE-LAYER SHIFTED HEATER	546
c -	Industry MEMS and Advancing MEMS for Products and Sustainability	у
]	Barriers to Commercialization & Research Needs for Future Products	
W24-c	LABOR-SAVING PLATFORM FOR CHARACTERIZATION OF MEMBRANE PROTEINS BY AUTOMATED MONITORING AND DATA REPORTING	550
c -	Industry MEMS and Advancing MEMS for Products and Sustainability	V
	MEMS Packaging Techniques	
M25-c	MODELLING IMPACT OF VISCOELASTIC PROPERTIES OF DIE-ATTACH MATERIAL ON THE BIAS RESPONSE OF RESONANT INERTIAL SENSORS Theo Miani ¹ , Lokesh Gurung ¹ , Guillermo Sobreviela-Falces ¹ , Douglas Young ¹ , Colin Baker ¹ , and Ashw. Seshia ² 1 Silicon Microgravity Ltd., UK and 2 University of Cambridge, UK	

b - Emerging Technologies and New Opportunities for MEMS/NEMS

	MEMS/NEMS - CMOS Integration	
Т25-с	CMOS-EMBEDDED 3D MICRO/NANOFLUIDICS EMPLOYING TOP-DOWN BEOL SINGLE-STEP WET-ETCHING TECHNIQUE Wei-Yang Weng, Hung-Yu Hou, Yueh-Jung Chao, Shwu-Jen Liaw, and Jun-Chau Chien National Taiwan University, TAIWAN	558
W25-c	IMPLEMENTATION OF A MONOLITHIC SOC ENVIRONMENTAL SENSING HUB USING CMOS-MEMS TECHNIQUE Ya-Chu Lee ¹ , Tung-Lin Chien ¹ , Chi-Te Fang ¹ , Yuanyuan Huang ¹ , Wei-Lun Sung ² , Yen-Chang Chu ² , Rongshun Chen ¹ , and Weileun Fang ¹ Inational Tsing Hua University, TAIWAN and PixArt Imaging Inc., TAIWAN	562
M26-c	MONOLITHICALLY AND VERTICALLY INTEGRATED ENVIRONMENTAL SENSING HUB WITH NOVEL AIR-BASED HUMIDITY SENSOR DESIGN	566
c -	Industry MEMS and Advancing MEMS for Products and Sustainability	y
	New MEMS System Design and Integration Approaches	
Т26-с	A SELF-CORRECTED, SELF-CLEANED MEMS AND SUITABLE FOR ADVANCED FOUNDRY MULTI-PROJECT WAFER (MPW)	570
W26-c	MONOLITHIC INTEGRATION OF HUMIDITY/FLOW/TEMPERATURE SENSORS AS ENVIRONMENT SENSING HUB FOR APPARENT-TEMPERATURE DETECTION	574
М27-с	PIEZORESISTIVE PRESSURE SENSOR WITH MONOLITHICALLY INTEGRATED AMPLIFIER BASED ON METAL-OXIDE TRANSISTORS Runxiao Shi ¹ , Dequan Lin ¹ , Kevin Chau ^{1,2} , and Man Wang ¹ ¹ Hong Kong University of Science and Technology, HONG KONG and ² Chinese Academy of Sciences, CHINA	578
d	- Materials, Fabrication and Packaging for Generic MEMS and NEMS	
	Advancement in Conventional Materials for MEMS & NEMS	
T27-d	A PERFORMANCE ENHANCEMENT METHOD FOR THERMOPILE SENSORS USING A CHIP PROBE TEST SYSTEM	582
W27-d	CHARACTERIZING INDUCTIVELY-COUPLED-PLASMA ETCHING OF SINGLE CRYSTALLINE LITHIUM TANTALATE FOR MICRO-ACOUSTIC APPLICATIONS	586
M28-d	ROBUST POLYCRYSTALLINE 3C-SIC-ON-SI HETEROSTRUCTURES WITH LOW CTE MISMATCH UP TO 900 °C FOR MEMS Philipp Moll, Georg Pfusterschmied, and Ulrich Schmid TU Wien. AUSTRIA	590

c - Industry MEMS and Advancing MEMS for Products and Sustainability

	Digital Micromanufacturing	
T28-d	A 3D PRINTED FUNCTIONAL MEMS ACCELEROMETER	594
W28-d	A FULLY 3D PRINTED METHOD FOR MONOLITHIC INTEGRATION OF AN ACCELEROMETER AND A FORCE SENSOR Guandong Liu ^{1,2} , Changhai Wang ¹ , Kexin Wang ¹ , Zhili Jia ³ , Ruiqi Luo ² , and Wei Ma ^{2,4} ¹ Heriot-Watt University, UK, ² Zhejiang Lab, CHINA, ³ National Institute of Metrology, CHINA, and ⁴ Zhejiang University, CHINA	598
d	- Materials, Fabrication and Packaging for Generic MEMS and NEMS	
	Generic MEMS & NEMS Manufacturing Techniques	
M29-d	CHARACTERIZATION OF VAPOR HF SACRIFICIAL ETCHING THROUGH SUBMICRON RELASE HOLES FOR WAFER-LEVEL VACUUM PACKAGING BASED ON SILICON MIGRATION SEAL Tianjiao Gong ¹ , Yukio Suzuki ¹ , Muhammad J. Khan ¹ , Karla Hiller ² , and Shuji Tanaka ¹ ¹ Tohoku University, JAPAN and ² Fraunhofer Institute for Electronic Nano Systems, GERMANY	602
T29-d	DAMAGE PROFILE MODELING AND EXPERIMENT OF SILICON CARBIDE SUBSTRATE IN MICRO-NANO STRUCTURE FABRICATED BY HELIUM FOCUSED ION BEAM	
W29-d	LIQUID-IMMERSION INCLINED-ROTATED UV LITHOGRAPHY FOR MICRO SUCTION CUP ARRAY	610
d	- Materials, Fabrication and Packaging for Generic MEMS and NEMS	
	New & Emerging Materials for MEMS/NEMS	
M30-d	PARAMETRIC AMPLIFICATION AND PHONONIC FREQUENCY COMB GENERATION IN MoS ₂ NANOELECTROMECHANICAL RESONATORS	
T30-d	PARYLENE-N AS A HIGH TEMPERATURE THIN FILM PIEZOELECTRIC MATERIAL Nathan Jackson and Deepak Kunwar University of New Mexico, USA	617
W30-d	SILICON CARBIDE-ON-INSULATOR THERMAL-PIEZORESISTIVE RESONATOR FOR HARSH ENVIRONMENT APPLICATION	
M31-d	SPIN COATING OF HIGHLY ALIGNED AGCN MICROWIRES EPITAXIALLY GROWN ON 2D MATERIALS Jimin Ham, Jaemook Lim, Joowon Lim, Gunyoung Jang, Sueng Yoon Lee, Dohyun Lim, Sukjoon Hong, and Won Chul Lee Hanyang Universit, Ansan, KOREA	625

d - Materials, Fabrication and Packaging for Generic MEMS and NEMS

T31-d	SUSPENDED TWO-DIMENSIONAL MATERIAL MEMBRANES FOR SENSOR APPLICATIONS FABRICATED WITH A HIGH-YIELD TRANSFER PROCESS	
W31-d	TCF-IMPROVED SH ₀ MODE ACOUSTIC RESONATORS BASED ON 30°YX-LINBO ₃ /SIO ₂ MEMBRANE	631
M32-d	WAFER SCALE MULTILAYER GRAPHENE BASED BRAIN PROBES BY SPIN-SPRAYING METHODS FOR MAGNETIC RESONANCE IMAGING	635
d	- Materials, Fabrication and Packaging for Generic MEMS and NEMS	
	New Fabrication Processes for Making MEMS/NEMS	
T32-d	3D SELF-ALIGNED FABRICATION OF SUSPENDED NANOWIRES BY CRYSTALLOGRAPHIC NANOLITHOGRAPHY Erwin J.W. Berenschot, Yasser Pordeli, Lucas J. Kooijman, Yves L. Janssens, Roald M. Tiggelaar, and Niels R. Tas University of Twente, NETHERLANDS	639
W32-d	A SIMPLE PROCESS FOR THE FABRICATION OF PARALLEL-PLATE ELECTROSTATIC MEMS RESONATORS BY GOLD THERMOCOMPRESSION BONDING	
M33-d	ELECTROMECHANICALLY STABLE INTERCONNECTION BETWEEN LIG AND THICK DAM-SHAPED METALLIC ELECTRODE VIA STORED AG MICROPARTICLE SOLUTION	647
T33-d	FREE-STANDING MEMBRANES WITH SELF-ASSEMBLED NANOPORE ARRAYS FOR TEM OBSERVATION OF LIQUID SAMPLES Joowon Lim ¹ , Jimin Ham ¹ , Sungho Jeon ¹ , Yuna Bae ^{2,3} , Minho Kang ^{2,3} , Sueng Yoon Lee ¹ , Jungwon Park ^{2,3} , and Won Chul Lee ¹ ¹ Hanyang University, KOREA, ² Seoul National University, KOREA, and ³ Institute of Basic Science (IBS), KOREA	651
W33-d	NONPLANAR NANOFABRICATION VIA INTERFACE ENGINEERING	653
M34-d	WAFER-LEVEL FABRICATION OF CONFORMAL SUB 10-NM NANOGAPS	657

	Packaging & Assembly	
T34-d	MEMS RESONATOR VACUUM-SEALED BY SILICON MIGRATION AND HYDROGEN OUTDIFFUSION Muhammad Jehanzeb Khan, Yukio Suzuki, Tianjiao Gong, Takashiro Tsukamoto, and Shuji Tanaka Tohoku University, JAPAN	661
W34-d	MEMS THIN-FILM VACUUM PACKAGE UTILIZING GLOW DISCHARGE GETTER	665
	e – MEMS Actuators and PowerMEMS	
	Actuator Components & Systems	
М35-е	LNOI THIN-FILM DUAL-AXIS RESONANT MICRO-MIRROR WITH E16 TORSIONAL ACTUATION Yaoqing Lu ^{1,2,3} , Kangfu Liu ^{1,2,3} , Yuxi Wang ^{1,2,3} , Ran Nie ¹ , and Tao Wu ^{1,2,3,4} ¹ ShanghaiTech University, CHINA, ² Chinese Academy of Sciences, CHINA, ³ University of Chinese Academy of Sciences, CHINA, and ⁴ Shanghai Engineering Research Center of Energy Efficient and Custom AI IC, CHINA	669
Т35-е	A PIEZOELECTRIC MEMS SPEAKER WITH STRETCHABLE FILM SEALING Linbing Xu, Mingchao Sun, Menglun Zhang, Chengze Liu, Xiaopeng Yang, and Wei Pang Tianjin University, CHINA	673
W35-e	BROADBAND MEMS SPEAKER BY SINGLE-WAY MULTI-RESONANCE ARRAY WITH ACOUSTIC DAMPING TUNING: A PROOF OF CONCEPT	677
М36-е	IONIC LIQUID ELECTROSPRAY THRUSTER WITH TWO-STAGE ELECTRODES ON GLASS SUBSTRATE	681
W36-e	MONOLITHIC INTEGRATION OF PZT ACTUATION UNITS OF VARIOUS ACTIVATED RESONANCES FOR FULL-RANGE MEMS SPEAKER ARRAY	685
М37-е	PULL-IN VOLTAGE REDUCTION IN ELECTROSTATIC AIRGAP ACTUATOR USING 12 NM-ULTRATHIN INTERNAL DIELECTRIC TRANSDUCTION Satish K. Verma and Bhaskar Mitra Indian Institute of Technology, New Delhi, INDIA	689
	e – MEMS Actuators and PowerMEMS	
	Energy Harvesting Materials, Structures, and Transducers	
Т37-е	A REVERSE ELECTROWETTING-ON-DIELECTRIC (REWOD) ENERGY HARVESTER USING NONWETTING GALLIUM COATED ELECTRODE AND ULTRATHIN GALLIUM OXIDE SHELL AS DIELECTRIC LAYER	693

d - Materials, Fabrication and Packaging for Generic MEMS and NEMS

W37-e	ASYMMETRIC QUAD LEG ORTHOPLANAR SPRING FOR WIDEBAND PIEZOELECTRIC MICRO ENERGY HARVESTING
М38-е	EVALUATION OF THERMOELECTRIC PROPERTIES OF MONOLITHICALLY-INTEGRATED CORE-SHELL Si NANOWIRE BRIDGES
Т38-е	GLAZE TILE-INSPIRED LIQUID-SOLID POWER GENERATOR FOR CONTINUOUS WATER FLOW ENERGY HARVESTING
W38-e	MEMS CANTILEVERED ENERGY HARVESTER WITH TAPERED THICKNESS FOR STRESS CONTROL
М39-е	TAPERED HELMHOLTZ RESONATOR WIND ENERGY HARVESTER DRIVEN BY AEROACOUSTICS
	e – MEMS Actuators and PowerMEMS
	Manufacturing for Actuators & Power MEMS
Т39-е	ANDROMEDA: A FLEXIBLE MEMS TECHNOLOGY PLATFORM FOR A VARIETY OF PIEZOELECTRICALLY ACTUACTED MICROMIRRORS
W39-e	DESIGN OF BUTTERFLY PLATE PIEZOELECTRIC ACTUATOR WITH DUAL DRIVING ELECTRODES FOR MEMS MICRO-MIRROR
М40-е	FULLY-FLEXIBLE MICRO-SCALE ACTUATOR ARRAY WITH THE LIQUID-GAS PHASE CHANGE MATERIALS
	e – MEMS Actuators and PowerMEMS
	Power MEMS Components & Systems
Т40-е	A NOVEL COMB DESIGN FOR ENHANCED POWER AND BANDWIDTH IN ELECTROSTATIC MEMS ENERGY CONVERTORS

	e – MEMS Actuators and PowerMEMS	
	Self-Powered Devices and Microsystems	
W40-e	A HYBRID NANOGENERTOR-DRIVEN SELF-POWERED WEARABLE PERSPIRATION MONITORING SYSTEM Md Abu Zahed, S M Sohel Rana, Md Sharifuzzaman, Seonghoon Jeong, Gagan Bahadur Pradhan, Hye Su Song, and Jae Yeong Park Kwangwoon University, KOREA	732
М41-е	A MONOLITHIC INTEGRATED AND TRANSPARENT MICROSYSTEM CONSTRUCTED BY USING AMORPHOUS INGAZNO FILM Bin Jia, Chao Zhang, and Xiaodong Huang Southeast University, CHINA	736
Т41-е	FLOWING WATER ENABLES STEERABLE CHARGE DISTRIBUTION ON ELECTRET SURFACE Boming Lyu ¹ , Jian Zhang ¹ , Yunjia Li ² , Yongqing Fu ³ , Honglong Chang ¹ , Weizheng Yuan ¹ , and Kai Tao ¹ Northwestern Polytechnical University, CHINA, ² Xi'an Jiaotong University, CHINA, and ³ University of Northumbria, UK	
W41-e	SELF-POWERED FLEXIBLE PIEZOELECTRET ARRAY FOR WEARABLE APPLICATIONS Hao Yang ^{1,2} , Rui M.R. Pinto ¹ , Pedro González ¹ , Alar Ainla ¹ , Mohammadmahdi Faraji ¹ , and K.B. Vinayakumar ¹ ¹ International Iberian Nanotechnology Laboratory, PORTUGAL and ² Xi'an Jiaotong University, CHINA	
	f - MEMS Physical and Chemical Sensors	
	Fluidic Sensors	
M42-f	A BULK-TYPE PRESSURE SENSOR WITH FULL-BRIDGE IMPLEMENTATION ENABLED BY STRESS-MODIFYING TRENCHES Dequan Lin ¹ , Man Wong ¹ , and Kevin Chau ^{1,2} I Hong Kong University of Science and Technology, CHINA, ² Chinese Academy of Science, CHINA	748
T42-f	A CMOS COMPATIBLE MICRO PIRANI GAUGE WITH STRUCTURE OPTIMIZATION FOR PERFORMANCE ENHANCEMENT Rui Jiao ¹ , Gai Yang ² , Ruoqin Wang ¹ , Yue Tang ² , Zhongyi Liu ² , Huikai Xie ^{2,3} , Hongyu Yu ¹ , and Xiaoyi Wang ^{2,3} ¹ Hong Kong University of Science and Technology, HONG KONG, ² Beijing Institute of Technology, CH. and ³ BIT Chongqing Institute of Microelectronics and Microsystems, CHINA	
W42-f	A THERMAL AIRFLOW SENSOR BASED ON MN-CO-NI-O THIN FILM	756
M43-f	HIGHLY SENSITIVE WAVE HEIGHT SENSOR WITH MEMS PIEZORESISTIVE CANTILEVER AND WATERPROOF MEMBRANE Takuto Hirayama and Hidetoshi Takahashi Keio University, JAPAN	760
T43-f	MEMS CAPACITANCE DIAPHRAGM GAUGE WITH TWO SEALED REFERENCE CAVITIES Xiaodong Han ^{1,2} , Jingzhen Li ³ , Gang Li ⁴ , and Yongjian Feng ¹ ¹ Xiamen University, CHINA, ² University of Twente, NETHERLANDS, ³ Beijing University of Technology, CHINA, and ⁴ Lanzhou Institute of Physics, CHINA	763
W43-f	TOWARDS A GAS INDEPENDENT THERMAL FLOW METER	767

	Force & Displacement Sensors	
M44-f	AN INTEGRATED MEMS DEVICE FOR IN-SITU FOUR-PROBE ELECTRO-MECHANICAL CHARACTERIZATION OF PT NANOBEAM	771
T44-f	FINGERLIKE TACTILE TEXTURE INTEGRATED SENSOR WITH COLD AND WARM SENSATIONS OF SUB-MM SPATIAL RESOLUTION	775
W44-f	MODIFIED BEAM STRUCTURES FOR IMPROVED RESONANT SENSING Erfan Ghaderi and Behraad Bahreyni Simon Fraser University, CANADA	779
M45-f	OCCLUSAL PAPER-BASED FLEXIBLE PRESSURE SENSOR FOR IN SITU MEASURING ORAL OCCLUSAL FORCE Wenduo Wang, Xin Zhang, Ning Zhao, Jingquan Liu, and Bin Yang Shanghai Jiao Tong University, CHINA	783
T45-f	SUCTION CUP ARRAY WORKING ALSO AS TACTILE SENSOR TO DETECT CUPS DEFORMATION USING KCF AND CNN Toshihiro Shiratori, Jinya Sakamoto, Yuki Kumokita, Masato Suzuki, Tomokazu Takahashi, and Seiji Aoyagi Kansai University, JAPAN	787
W45-f	VERTICAL INTEGRATION OF FORCE TRANSMISSION STRUCTURE ON CAPACITIVE CMOS-MEMS TACTILE FORCE SENSOR FOR SENSITIVITY IMPROVEMENT	791
	f - MEMS Physical and Chemical Sensors	
	Gas & Chemical Sensors	
M46-f	1-OCTADECANETHIOL SAM ON CMOS-MEMS GOLD PLATED RESONATOR VIA DIP-CAST FOR VOCs SENSING Rafel Perelló-Roig ^{1,2} , Jaume Verd ^{1,2} , Sebastià Bota ^{1,2} , Bartomeu Soberats ¹ , Antonio Costa ¹ , and Jaume Segura ^{1,2} ¹ University of the Balearic Islands, SPAIN and ² Health Research Institute of the Balearic Islands, SPAIN	
T46-f	APPLICATION OF DEEP LEARNING NETWORK FOR HUMIDITY COMPENSATION OF SEMICONDUCTOR METAL OXIDE GAS SENSORS Mingu Kang, Incheol Cho, and Inkyu Park Korea Advanced Institute of Science and Technology (KAIST), KOREA	799
W46-f	DEVELOPMENT OF MONOLITHIC MICRO-LED GAS SENSOR BASED E-NOSE SYSTEM FOR REAL-TIME, SELECTIVE GAS PREDICTION Kichul Lee, Mingu Kang, and Inkyu Park Korea Advanced Institute of Science and Technology (KAIST), KOREA	803
M47-f	ELECTRONIC-NOSE: AN ARRAY OF 16 MOS-GAS SENSORS INTEGRATED WITH TEMPERATURE AND MOISTURE SENSING CAPABILITIES	ırch

f - MEMS Physical and Chemical Sensors

T47-f	ENHANCEMENT OF SENSITIVITY IN PHOTONIC CRYSTAL BASED CHEMICAL SENSOR USING CHEMO-MECHANICAL BILAYER EFFECT Seyeon Lee ¹ , Naik T. Banabathi ¹ , Dongwon Kang ³ , Sookyung Kang ² , Kyungsuk Cho ² , Jungwook Kim ¹ , and Jungyul Park ¹ **ISogang University, KOREA, **Iwha University, KOREA, and **University of California, Los Angeles, US.**	
W47-f	METAL ION RECOGNITION SENSOR BASED ON RESISTANCE SWITCHING EFFECT Tian Kang, Yusa Chen, Guanzhou Lin, Shengxiao Jin, Liye Li, Hongshun Sun, Senyong Hu, and Wengang Wu Peking University, CHINA	814
M48-f	MULTI-HOTSPOT MID-IR NANOANTENNAS WITH MATCHED LOSS AND HIGH-INTENSITY NEAR-FIELD FOR SUB-PPM-LEVEL GAS DETECTION	818
T48-f	PALLADIUM BASED MEMS HYDROGEN SENSORS	822
W48-f	SELECTIVE DISCRIMINATION OF PPB-LEVEL VOCS USING MOS GAS SENSOR IN PULSE-HEATING MODE WITH THE MODIFIED HILL'S MODEL	826
M49-f	THERMAL CONDUCTIVITY DETECTOR (TCD)-TYPE GAS SENSOR BASED ON THE SUSPENDED 1D NANOHEATER FOR IOT APPLICATIONS Wootaek Cho, Jong-Hyun Kwak, Taejung Kim, and Heungjoo Shin Ulsan National Institute of Science and Technology (UNIST), KOREA	830
	f - MEMS Physical and Chemical Sensors	
	Inertial Sensors	
T49-f	120 PPM QUALITY FACTOR THERMAL STABILITY FROM -40°C TO +60°C OF A DUAL-AXIS MEMS GYROSCOPE BASED ON JOULE EFFECT DYNAMIC CONTROL Jian Cui ^{1,2} and Qiancheng Zhao ^{1,2} ¹ Peking University, CHINA and ² Beijing Advanced Innovation Center for Integrated Circuits, CHINA	833
W49-f	A FORCE-BANLANCE CAPACITIVE MEMS GRAVIMETER WITH SUPERIOR RESPONSE TIME, SELF-NOISE AND DRIFT Le Gao¹, Fangzheng Li¹, Jian Zhang¹, Bingyang Cai¹, Wenjie Wu¹, and Liangcheng Tu² ¹Huazhong University of Science and Technology, CHINA and ²Sun Yat-sen University, CHINA	837
M50-f	A MEMS-BASED GRAVIMETER FOR SIMULTANEOUS VERTICAL AND HORIZONTAL EARTH TIDES MEASUREMENTS Lujia Yang¹, Xiaochao Xu¹, Qian Wang¹, Ji'ao Tian¹, Yanyan Fang¹, Chun Zhao¹, Wenjie Wu¹, Fangjing Hu¹, and Liangcheng Tu¹.² ¹Huazhong University of Science and Technology, CHINA and ²Sun Yat-sen University, CHINA	841
T50-f	A NOVEL MULTIPLE FOLDED BEAM DISK RESONATOR FOR MAXIMIZING THE THERMOELASTIC QUALITY FACTOR Xiaopeng Sun ¹ , Xin Zhou ¹ , Lei Yu ² , Kaixuan He ² , Xuezhong Wu ¹ , and Dingbang Xiao ¹ ¹ National University of Defense Technology, CHINA and ² East China Institute of Photo-Electronic IC, CHINA	845

W50-f	A TIME-SERIES CONFIGURATION METHOD OF MODE REVERSAL MEMS GYROSCOPES UNDER DIFFERENT TEMPERATURE-VARYING CONDITIONS Liangqian Chen, Tongqiao Miao, Qingsong Li, Peng Wang, Junjian Li, Xuezhong Wu, Dingbang Xiao, and Xiang Xi National University of Defense Technology, CHINA	. 849
M51-f	ACOUSTICALLY ISOLATED MEMS BAW GYROSCOPES Diego Emilio Serrano, Amir Rahafrooz, Duane Younkin, Kieran Nunan, Mitul Dalal, Sagnik Pal, and Ijaz Jafri Panasonic Device Solutions Laboratory of Massachusetts, USA	. 853
T51-f	ACTIVE QUALITY FACTOR STABILIZATION OF MEMS RESONATOR UTILIZING ELECTRICAL DISSIPATION REGULATION Yang Zhao, Qin Shi, Guoming Xia, and Anping Qiu Nanjing University of Science and Technology, CHINA	. 857
W51-f	DEMONSTRATION OF GYRO-LESS NORTH FINDING USING A T-SHAPED MEMS DIFFERENTIAL RESONANT ACCELEROMETER	. 861
M52-f	ENHANCED STIFFNESS SENSITIVITY IN A MODE LOCALIZED SENSOR USING INTERNAL RESONANCE ACTUATION	. 865
T52-f	MODELING STRESS EFFECTS ON FREQUENCIES OF A MEMS RING GYROSCOPE Mehran Hosseini-Pishrobat, Baha Erim Uzunoglu, and Erdinc Tatar Bilkent University, TURKEY	. 869
W52-f	RATE INTEGRATING GYROSCOPE TUNED BY FOCUS ION BEAM TRIMMING AND INDEPENDENT CW/CCW MODES CONTROL Jianlin Chen ¹ , Takashiro Tsukamoto ¹ , Giacomo Langfelder ² , and Shuji Tanaka ¹ ¹ Tohoku University, JAPAN and ² Politecnico di Milano, ITALY	. 873
M53-f	TEMPERATURE DEPENDENCE OF QUALITY FACTORS AT HIGH FREQUENCIES IN MEMS GYROSCOPES Daniel Schiwietz ^{1,2} , Eva M. Weig ² , and Peter Degenfeld-Schonburg ¹ ¹ Robert Bosch GmbH, GERMANY and ² Technical University of Munich, GERMANY	. 877
	f - MEMS Physical and Chemical Sensors	
	Manufacturing Techniques for Physical Sensors	
T53-f	0.5MM×0.5MM 150KPA-MEASURE-RANGE HIGH-TEMPERATURE PRESSURE SENSOR WITH HIGH-PERFORMANCE AND LOW FABRICATION-COST Peng Li ^{1,2} , Wei Li ¹ , Changnan Chen ^{1,3} , Ke Sun ¹ , Min Liu ¹ , Sheng Wu ¹ , Pichao Pan ^{1,3} , Jiachou Wang ^{1,3} , and Xinxin Li ^{1,2,3} ¹ Chinese Academy of Sciences, CHINA, ² Fudan University, CHINA, and ³ University of Chinese Academy of Sciences, CHINA	. 881
W53-f	AUTOMATIC PICO LASER TRIMMING SYSTEM FOR SILICON MEMS RESONANT DEVICES BASED ON IMAGE RECOGNITION Yuxian Liu ¹ , Qiancheng Zhao ^{1,2} , Dacheng Zhang ¹ , and Jian Cui ^{1,2} ¹ Peking University, CHINA and ² Beijing Advanced Innovation Center for Integrated Circuits, CHINA	. 885
M54-f	MICROMACHINING FUSED SILICA MICRO SHELL RESONATOR WITH QUARTZ GLASS MOLD BY THERMAL REFLOW Zhaoxi Su, Bin Luo, Qiankai Tang, Linqian Zhu, and Jintang Shang Southeast University, CHINA	. 889

T54-f	WAFER-LEVEL PATTERNING OF TIN OXIDE	902
	NANOSHEETS FOR MEMS GAS SENSORS	093
	f - MEMS Physical and Chemical Sensors	
	Materials for Physical Sensors	
W54-f	AIR DAMPING EFFECTS ON DIFFERENT MODES OF AIN-on-Si MICROELECTROMECHANICAL RESONATORS Yuncong Liu ¹ , S M Enamul Hoque Yousuf ¹ , Afzaal Qamar ² , Mina Rais-Zadeh ^{2,3} , and Philip XL. Feng ¹	
	¹ University of Florida, USA, ² University of Michigan, USA, and ³ California Institute of Technology, USA	
M55-f	A NOVEL PIEZORESISTIVE PRESSURE SENSOR BASED ON CR-DOPED V ₂ O ₃ THIN FILM	001
	Michiel Gidts, Wei-Fan Hsu, María Recaman Payo, Shashwat Kushwaha, Chen Wang, Frederik Ceyssens, Dominiek Reynaerts, Jean-Pierre Locquet, and Michael Kraft KU Leuven, BELGIUM	901
	f - MEMS Physical and Chemical Sensors	
	Metrology and Measurement Techniques for MEMS/NEMS Sensors	
T55-f	A NOVEL FEEDTHROUGH CANCELLATION TECHNIQUE FOR PIEZOELECTRIC MEMS RESONANT SENSORS IN IONIC LIQUID MEDIUM	905
W55-f	CHARACTERIZATION OF PACKAGING STRESS WITH	
	A CAPACITIVE STRESS SENSOR ARRAY Tolga Veske ¹ , Derin Erkan ¹ , and Erdinc Tatar ^{1,2}	909
	¹ Bilkent University, TURKEY and ² National Nanotechnology Research Center (UNAM), TURKEY	
M56-f	MILLISECOND-LEVEL PULSE-HEATING SENSING SYSTEM	012
	FOR MEMS-BASED GAS SENSORS Yi Zhuang, Gaoqiang Niu, Lang Wu, and Fei Wang Southern University of Science and Technology, CHINA	913
T56-f	MULTIPLE PARAMETER DECOUPLING USING A SINGLE	
	RESONANT MEMS SENSOR VIA BLUE SIDEBAND EXCITATION	917
	Huafeng Liu ¹ , Chen Wang ⁴ , Michael Kraft ⁴ , and Chun Zhao ³	
	¹ Huazhong University of Science and Technology, CHINA, ² University of Macau, CHINA, ³ University of York, UK, and ⁴ University Leuven, BELGIUM	
	f - MEMS Physical and Chemical Sensors	
	Nanoscale Physical Sensors	
W56-f	DIAMOND NANOWIDES ADDAY DDEDADED DV ANNEAL INC NANO CDVSTALL INE	
W 30-1	DIAMOND NANOWIRES ARRAY PREPARED BY ANNEALING NANO-CRYSTALLINE DIAMOND IN AIR AND ITS APPLICATION IN FIELD EMISSION	921
	Yang Wang, Chen Lin, and Jinwen Zhang Peking University, CHINA	
M57-f	QUANTIFIED STRESS RELAXATION IN CARBON NANOTUBE RESONATORS	925
	Morten Vollmann, Cosmin Roman, Miroslav Haluska, and Christofer Hierold ETH Zürich, SWITZERLAND	

T57-f	SELF-REFERENCED TEMPERATURE SENSORS BASED ON CASCADED SILICON RING RESONATOR Xiantao Zhu, Minmin You, Zude Lin, Bin Yang, and Jingquan Liu Shanghai Jiao Tong University, CHINA	929
	f - MEMS Physical and Chemical Sensors	
	Sonic & Ultrasonic MEMS Transducers	
W57-f	A 0.35 mm² SYSTEM ON CHIP LEVEL DETECTOR BASED ON AN ANNULAR PMUT-ON-CMOS ARRAY Eyglis Ledesma, Iván Zamora, Francesc Torres, Arantxa Uranga, and Núria Barniol Universitat Autônoma de Barcelona, SPAIN	933
M58-f	AN ALSCN PMUT-ON-CMOS SENSOR FOR MONITORING FLUIDS' DENSITY, VISCOSITY, SOUND VELOCITY, AND COMPRESSIBILITY	937
T58-f	AUTO-POSITIONING AND HAPTIC STIMULATIONS VIA A 35 MM SQUARE PMUT ARRAY Wei Yue ¹ , Yande Peng ¹ , Hanxiao Liu ¹ , Fan Xia ¹ , Fanping Sui ¹ , Seiji Umezawa ² , Shinsuke Ikeuchi ² , Yasuhiro Aida ² , and Liwei Lin ¹ ¹ University of California, Berkeley, USA and ² Murata Manufacturing Co., Ltd., JAPAN	941
W58-f	BODY FORCE BASED DROPLET EJECTION BY GHZ ACOUSTIC MICRO-TRANSDUCER Haitao Zhang, Yangchao Zhou, Menglun Zhang, Wenlan Guo, Chen Sun, Xuexin Duan, and Wei Pang Tianjin University, CHINA	945
M59-f	BONE CONDUCTION PICKUP BASED ON PIEZOELECTRIC MICROMACHINED ULTRASONIC TRANSDUCERS Chongbin Liu ¹ , Xiangyang Wang ¹ , Yong Xie ² , and Guoqiang Wu ¹ *IWuhan University, CHINA and *2Xidian University, CHINA*	949
T59-f	BREAKING THE DEAD ZONE LIMITATION OF PMUTS BASED ON A PHASE SHIFT OF DRIVING WAVEFORM WITH WINDOW FUNCTION Chun-You Liu, Chin-Yu Chang, and Sheng-Shian Li National Tsing Hua University, TAIWAN	953
W59-f	DRONE-MOUNTED LOW-FREQUENCY PMUTS FOR > 6-METER RANGEFINDER IN AIR Hanxiao Liu¹, Yande Peng¹, Wei Yue¹, Seiji Umezawa², Shinsuke Ikeuchi², Yasuhiro Aida², Chunming Chen¹, Peggy Tsao¹, and Liwei Lin¹ ¹University of California, Berkeley, USA and ²Murata Manufacturing Co., Ltd., JAPAN	957
M60-f	MASS PRODUCED MICROMACHINED ULTRASONIC TIME-OF-FLIGHT SENSORS OPERATING IN DIFFERENT FREQUENCY BANDS	961
T60-f	MEMS FIRST-ORDER BESSEL BEAM ACOUSTIC TRANSDUCER FOR PARTICLE TRAPPING AND CONTROLLABLE ROTATING Jiaqi Li¹, Zhenhuan Sun¹, Yuyu Jia¹, Teng Li¹, Haojian Lu², Lurui Zhao³, Hai Liu³, and Song Liu¹ ShanghaiTech University, CHINA, ² Zhejiang University, CHINA, and Juniversity of Southern California, Los Angeles, USA	965

W60-f	NON-INVASIVE CAROTID ARTERY MONITORING BY USING ALUMINUM NITRIDE PMUT CLOSE-PACKED ARRAYS Sheng Wu ^{1,2,3} , Kangfu Liu ² , Shuai Shao ² , Wei Li ^{1,3} , Ying Chen ^{1,3} , Tao Wu ² , and Xinxin Li ^{1,3} ¹ Chinese Academy of Sciences, CHINA, ² ShanghaiTech University, CHINA, and ³ University of Chinese Academy of Sciences, CHINA	. 969
M61-f	NON-LINEAR BEHAVIORAL MODELING OF CAPACITIVE MEMS MICROPHONES	. 973
T61-f	VORTEX-BEAM ACOUSTIC TRANSDUCER FOR UNDERWATER PROPULSION	. 977
W61-f	WIDEBAND AND HIGHLY SENSITIVE MICROMACHINED PZT FILM-BASED ULTRASONIC MICROPHONE WITH PARYLENE FILM AND FLEXIBLE HELMHOLTZ RESONATOR ENHANCEMENT Chung-Hao Huang and Guo-Hua Feng National Tsing Hua University, TAIWAN	. 981
	f - MEMS Physical and Chemical Sensors	
	Other Physical Sensors	
M62-f	HALBACH-ARRAY MAGNETIC COIL ARRANGEMENT ON CMOS CHIP FOR SENSITIVITY ENHANCEMENT OF INDUCTIVE TACTILE SENSOR Tien Chou, Zih-Song Hu, and Weileun Fang National Tsing Hua University, TAIWAN	. 985
T62-f	ON-MEMS-CHIP COMPACT TEMPERATURE SENSOR FOR LARGE-VOLUME, LOW-COST SENSOR CALIBRATION Paolo Frigerio ¹ , Andrea Fagnani ¹ , Valentina Zega ¹ , Gabriele Gattere ² , Attilio Frangi ¹ , and Giacomo Langfelder ¹ 1Politecnico di Milano, ITALY and 2STMicroelectronics, ITALY	. 989
W62-f	PARTICULATE MATTER SENSOR BASED ON TWO STAGE CASCADE VIRTUAL IMPACTORS AND THERMOPHORETIC MICROHEATERS	. 993
	g – Micro- and Nanofluidics	
	Biological and Medical Microfluidics and Nanofluidics	
M63-g	A MICROFLUIDIC OXYGEN GRADIENT GENERATOR FOR THE STUDY OF AEROTROPISM IN HYPHAE OF OOMYCETES Ayelen Tayagui ^{1,2} , Yiling Sun ^{1,2} , Ashley Garrill ¹ , and Volker Nock ^{1,2} ¹ University of Canterbury, NEW ZEALAND and ² MacDiarmid Institute for Advanced Materials and Nanotechnology, NEW ZEALAND	. 997
Т63-д	A PAPER-BASED DUAL APTAMER ASSAY ON AN INTEGRATED MICROFLUIDIC SYSTEM FOR DETECTION OF HNP 1 AS A BIOMARKER FOR PERIPROSTHETIC JOINT INFECTIONS	1001

W63-g	AN INTEGRATED MICROFLUIDIC PLATFORM FOR TUMOR CELL SEPARATION AND FLUORESCENCE IN SITU HYBRIDIZATION AT SINGLE CELL LEVEL	1005
M64-g	CHARACTERIZATION OF OOCYTE HARDENING USING A MICROFLUIDIC ASPIRATION-ASSISTED ELECTRICAL IMPEDANCE SPECTROSCOPY SYSTEM	1009
T64-g	DOUBLE PULSE IRRADIATION OF FS LASER FOR ENHANCING THE PERFORMANCE OF PRECISE LASER SORTING METHOD Ryota Kiya ¹ , Yoshinaga Rintaro ¹ , Yo Tanaka ² , Yaxiaer Yalikun ^{1,2} , and Yoichiroh Hosokawa ¹ ¹ Nara Institute of Science and Technology, JAPAN and ² Institute of Physical and Chemical Research (RIKEN), JAPAN	1013
W64-g	DROPLET BASED HIGH THROUGHPUT SINGLE-SPERM CRYOPRESERVATION PLATFORM Na Li ^{1,2} , Shihui Qiu ^{1,3} , Zhenhua Wu ^{1,3} , and Hongju Mao ^{1,3} ¹ Chinese Academy of Sciences, CHINA, ² ShanghaiTech University, CHINA, and ³ University of Chinese Academy of Sciences, CHINA	1017
M65-g	DUAL ION-SELECTIVE MEMBRANE DEPOSITED ION-SENSITIVE FIELD-EFFECT TRANSISTOR (DISM-ISFET) INTEGRATING WHOLE BLOOD PROCESSING MICROCHAMBER FOR IN SITU BLOOD ION TESTING	1021
	g – Micro- and Nanofluidics	
	Generic Microfluidics & Nanofluidics	
W65-g	STRONG MICROSTREAMING FROM A PINNED OSCILLATING MEMBRANE AND APPLICATION TO GAS EXCHANGE Anthony L. Mercader and Sung Kwon Cho University of Pittsburgh, USA	1025
M66-g	TUNABLE NANOPORE-INTEGRATED MICRO-/NANOFLUIDIC PLATFORM FOR ION TRANSPORT CONTROL IN THE PRESENCE OF CONCENTRATION AND TEMPERATURE GRADIENTS Dongwoo Seo ¹ , Dongjun Kim ¹ , Jongwan Lee ¹ , Cong Wang ² , Jungyul Park ² , and Taesung Kim ¹ ¹ Ulsan National Institute of Science and Technology (UNIST), KOREA and ² Sogang University, KOREA	
	g – Micro- and Nanofluidics	
Int	tegrated/Embedded Microfluidics and Nanofluidic Systems & Platform	S
W66-g	QUANTITATIVE ASSESSMENT OF CAPTURED MAGNETIC NANOPARTICLES USING SELF-POWERED MAGNETOELECTRIC PLATFORM FOR BIOLOGICAL APPLICATIONS Pankaj Pathak, Vinit K. Yadav, Samaresh Das, and Dhiman Mallick Indian Institute Of Technology Delhi, INDIA	1033
M67-g	REAL-TIME OPERATION OF MICROCANTILEVER-BASED IN-PLANE RESONATORS PARTIALLY IMMERSED IN A MICROFLUIDIC SAMPLER Jiushuai Xu, Entian Cao, Michael Fahrbach, Vladislav Agluschewitsch, Andreas Waag, and Erwin Pein Technische Universität Braunschweig, GERMANY	

T67-g	SUSPENDED NANOCHANNEL RESONATORS MADE BY NANOIMPRINT AND GAS PHASE DEPOSITION	
	Manuel Müller ¹ , Jeremy Teuber ¹ , Rukan Nasri ¹ , Francesc Torres Canals ² , Núria Barniol ² , Jordi Llobet Sixto ³ , Xavier Borrise ³ , Francesc Perez-Murano ³ , and Irene Fernandez-Cuesta ¹ University of Hamburg, GERMANY, ² Universitat Autónoma de Barcelona, SPAIN, and ³ IMB-CNM CSIC, SPAIN	
	g – Micro- and Nanofluidics	
	Manufacturing for Micro- and Nanofluidics	
W67-g	DEVELOPING AN EXTREMELY HIGH FLOW RATE PNEUMATIC PERISTALTIC MICROPUMP FOR BLOOD PLASMA SEPARATION WITH INERTIAL PARTICLE FOCUSING TECHNIQUE FROM FINGERTIP BLOOD WITH LANCETS	. 1045
M68-g	DIRECT PATTERNING ON POROUS SURFACE USING DROP IMPACT PRINTING	1049
Т68-д	MANUFACTURING 3D-PRINTED PAPER MICROFLUIDICS INTEGRATED WITH IONIZATION MASS-SPECTROMETRY FOR ILLICIT DRUGS ANALYSIS AND ON-CHIP CHROMATOGRAPHY Muhammad Faizul Zaki ¹ , Pin-Chuan Chen ¹ , Yi-Xin Wu ² , and Pai-Shan Chen ² ¹ National Taiwan University of Science and Technology, TAIWAN and ² National Taiwan University, TAIWAN	. 1052
	g – Micro- and Nanofluidics	
	Materials for Micro & Microfluidics	
W68-g	DETECTION LIMITS IN NANOMECHANICAL MASS FLOW SENSING FOR NANOFLUIDICS WITH NANOWIRE OPEN CHANNELS Javier E. Escobar, Juan Molina, Eduardo Gil-Santos, José J. Ruz, Óscar Malvar, Priscila M. Kosaka, Javier Tamayo, Álvaro San Paulo, and Montserrat Calleja Instituto de Micro y Nanotecnología, IMN-CNM (CSIC), SPAIN	1056
	g – Micro- and Nanofluidics	
	Modeling of Micro & Nanofluidics	
М69-д	CONTROLLING PARTICLE AGGREGATION AND SEPARATION IN LIQUID ON MEMBRANE RESONATORS Haoran Zhang ^{1,2} , Hao Jia ^{1,2} , and Xinxin Li ^{1,2} ¹ Chinese Academy of Sciences, CHINA and ² University of Chinese Academy of Sciences, CHINA	1060
Т69-д	DEVELOPMENT OF BOAT MODEL POWERED BY ELECTRO-HYDRODYNAMIC PROPULSION SYSTEM Luan Ngoc Mai ^{1,2} , Tuan-Khoa Nguyen ³ , Trung Hieu Vu ³ , Thien Xuan Dinh ⁴ , Canh-Dung Tran ⁵ , Hoang Phuong Phan ⁶ , Toan Dinh ⁵ , Thanh Nguyen ⁵ , Nam-Trung Nguyen ³ , Dzung Viet Dao ³ , and Van Thanh II Ho Chi Minh City University of Technology, VIETNAM, ² Vietnam National University Ho Chi Minh CVIETNAM, ³ Griffith University, AUSTRALIA, ⁴ Explosion Research Institute Inc., JAPAN, ⁵ University of Southern Queensland, AUSTRALIA, and ⁶ University of New South Wales, AUSTRALIA	g- Dau ³ C <i>ity</i> ,

W69-g M70-g	HEMODYNAMIC ANALYSIS OF CARDIOMEMS: ADVERSE HEMODYNAMIC EFFECTS Zhenhao Liu ¹ , Jiangli Han ² , and Xing Chen ¹	
	****IBeihang University, CHINA and **Peking University Third Hospital, CHINA ***MODAL QUALITY FACTOR INVERSION OF NON-SLENDER **MEMS RESONATORS BETWEEN GASES AND LIQUIDS** **Andre L. Gesing, Thomas Tran, Daniel Platz, and Ulrich Schmid **TU Wien, AUSTRIA**	1072
	g – Micro- and Nanofluidics	
	Other Micro- and Nanofluidics	
Т70-д	CLASSIFYING CELL CYCLE BY ELECTRICAL PROPERTIES USING MACHINE LEARNING Jian Wei and Xiaoxing Xing Beijing University of Chemical Technology, CHINA	1076
W70-g	HIGH-THROUGHPUT SPHERICAL SUPRAPARTICLE SELF-ASSEMBLY BY ENHANCED EVAPORATION OF COLLOIDAL WATER DROPLETS THROUGH THIN FILM OF WATER-SOLUBLE OIL Wonhyung Lee, Joowon Rhee, and Joonwon Kim Pohang University of Science and Technology (POSTECH), KOREA	1080
M71-g	IN-ICE POLYMERIZATION FOR FUNCTIONAL HYDROGEL MICROBEAD WITH FLASH FREEZING CENTRIFUGAL MICROFLUIDIC DEVICE	1084
T71-g	TEMPERATURE-RESPONSIVE MICROCAPSULES MANUFACTURED BY PROMOTING CONTROLLED CLOAKING WITH THE HELP OF MICRO/NANOPARTICLES	1088
W71-g	WATER VITRIFICATION IN A MICROCHANNEL AT LOW COOLING RATE	1091
	h - Optical, RF and Electromagnetics for MEMS/NEMS	
	Electrical Field and Magnetic Field Sensors and Transducers	
M72-h	A HIGHLY SENSITIVE 3-AXIS MICRO SEARCH-COIL MAGNETOMETER ENABLED BY HIGH DENSITY THROUGH-SILICON-VIA PROCESS	1095
T72-h	FULLY INTEGRATED BACK-BIASED 3D HALL SENSOR WITH WAFER-LEVEL INTEGRATED PERMANENT MICROMAGNETS	

h - Optical, RF and Electromagnetics for MEMS/NEMS Free Space Optical Components & Systems

W72-h	A LARGE-STROKE TIP-TILT-PISTON MICROMIRROR WITH ELECTROMAGNETIC ACTUATORS BASED ON METALLIC GLASS	03
M73-h	ARBITRARY SHAPED BACKSIDE REINFORCEMENT FOR TWO DIMENSIONAL RESONANT MICROMIRRORS	07
T73-h	HIGH TRANSMITTANCE METASURFACE HOLOGRAMS USING SILICON NITRIDE 11 Masakazu Yamaguchi, Hiroki Saito, Satoshi Ikezawa, and Kentaro Iwami Tokyo University of Agriculture and Technology, JAPAN	11
W73-h	MULTIFUNCTIONAL OPTICAL METASURFACE FOR ANOMALOUS REFLECTION, STRUCTURAL COLOR, AND SURFACE LATTICE RESONANCE	15
M74-h	NOVEL WAVEFRONT-SPLITTING INTERFEROMETER FOR ULTRA-COMPACT BROADBAND FT-IR SPECTROSCOPY EXTENDING TO VISIBLE RANGE	19
T74-h	PIEZOELECTRICALLY ACTUATED MICROMIRROR WITH DYNAMIC DEFORMATION COMPENSATION MECHANISM	
W74-h	RESONANT d ₃₃ MODE PZT MEMS MIRROR EXCITED WITH DIRECTIONAL INTERDIGITATED ELECTRODES	27
M75-h	RESONANT PIEZOELECTRIC VARIFOCAL MIRROR WITH ON-CHIP INTEGRATED DIFFRACTIVE OPTICS FOR INCREASED FREQUENCY RESPONSE	31
T75-h	UNIQUE DISPERSION RELATION FOR PLASMONIC PHOTODETECTORS WITH SUBMICRON GRATING	35
	h - Optical, RF and Electromagnetics for MEMS/NEMS	
	Infrared (IR) Sensors and Imaging Systems	
W75-h	INTEGRATION OF A HIGH TEMPERATURE TRANSITION METAL OXIDE NTC THIN FILM IN A MICROBOLOMETER FOR LWIR DETECTION	

M76-h	PERIODIC CAVITIES ON THE IR-ABSORBER FOR RESPONSIVITY ENHANCEMENT OF CMOS-MEMS THERMOELECTRIC IR SENSOR Yung-Chen Li, Tien Chou, Pen-Sheng Lin, Yu-Cheng Huang, Fuchi Shih, You-An Lin, Da-Jen Yen, Mei-Feng Lai, and Weileun Fang National Tsing Hua University, TAIWAN	1143
T76-h	ULTRA-LARGE PIXEL ARRAY PHOTOTHERMAL TRANSDUCER AND ITS THERMAL PERFORMANCE PREDICTION STRATEGY Defang Li ^{1,3} , Jinying Zhang ^{1,2} , Jiushuai Xu ³ , Erwin Peiner ³ , Zhuo Li ^{1,2} , Xin Wang ¹ , Suhui Yang ¹ , and Yanze Gao ¹ Beijing Institute of Technology, CHINA, ² Yangtze Delta Region Academy of Beijing Institute of Technology, CHINA, and ³ Technische Universität Braunschweig, GERMANY	
	h - Optical, RF and Electromagnetics for MEMS/NEMS	
	MEMS for Timing & Frequency Control	
W76-h	A CMOS-MEMS BEAM RESONATOR WITH Q > 10,000 Ting-Yi Chen and Wei-Chang Li National Taiwan University, TAIWAN	1151
M77-h	GENERIC TEMPERATURE COMPENSATION SCHEME FOR CMOS-MEMS RESONATORS BASED ON ARC-BEAM DERIVED ELECTRICAL STIFFNESS FREQUENCY PULLING I-Chieh Hsieh, Hong-Sen Zheng, Chun-Pu Tsai, Ting-Yi Chen, and Wei-Chang Li National Taiwan University, TAIWAN	1155
T77-h	HIGH-Q AND LOW-MOTIONAL IMPEDANCE PIEZOELECTRIC MEMS RESONATOR THROUGH MECHANICAL MODE COUPLING Linhai Huang ¹ , Zhihong Feng ¹ , Yuhao Xiao ² , Fengpei Sun ¹ , and Jinghui Xu ¹ ¹ Huawei Technologies Company Ltd., CHINA and ² Wuhan University, CHINA	1159
	h - Optical, RF and Electromagnetics for MEMS/NEMS	
	Photonic Components & Systems	
W77-h	CROSSTALK-FREE LARGE APERTURE 2D GIMBAL MICROMIRROR	1163
M78-h	INVERSE INTERFERENCE EFFECT-ENHANCED ULTRASENSITIVE SENSING VIA MID-IR NANOANTENNAS Hong Zhou, Dongxiao Li, Xinge Guo, Zhihao Ren, and Chengkuo Lee National University of Singapore, SINGAPORE	1167
T78-h	TWISTED AND CONTACTED AU MICRO-RODS 3D CHIRAL METAMATERIALS WITH CIRCULAR DICHROISM VIA AN ABSORPTIVE ROUTE IN LONG-WAVELENGTH INFRARED	1171

h - Optical, RF and Electromagnetics for MEMS/NEMS RF MEMS Components & Systems

W78-h	3D HYBRID ACOUSTIC RESONATOR WITH COUPLED FREQUENCY RESPONSES OF SURFACE ACOUSTIC WAVE AND BULK ACOUSTIC WAVE Liping Zhang ^{1,2} , Shibin Zhang ¹ , Jinbo Wu ^{1,2} , Pengcheng Zheng ^{1,2} , Hulin Yao ^{1,2} , Yang Chen ^{1,2} , Kai Huang ^{1,2} , Xiaomeng Zhao ¹ , Min Zhou ¹ , and Xin Ou ^{1,2} ¹ Chinese Academy of Sciences, CHINA and ² University of Chinese Academy of Sciences, CHINA	. 1175
M79-h	A C/K _U DUAL-BAND RECONFIGURABLE BAW FILTER USING POLARIZATION TUNING IN LAYERED SCALN Dicheng Mo, Shaurya Dabas, Sushant Rassay, and Roozbeh Tabrizian University of Florida, USA	. 1179
T79-h	ACOUSTOELECTRIC-DRIVEN FREQUENCY MIXING IN MICROMACHINED LITHIUM NIOBATE ON SILICON WAVEGUIDES	. 1183
W79-h	EFFECT OF SCANDIUM COMPOSITION ON THE PHONON SCATTERING LIFETIME OF ALUMINUM SCANDIUM NITRIDE ACOUSTIC WAVE RESONATORS Yue Zheng ¹ , Mingyo Park ¹ , Chao Yuan ² , and Azadeh Ansari ¹ Georgia Institute of Technology, USA and ² Wuhan University, CHINA	. 1186
M80-h	LITHIUM NIOBATE THIN FILM BASED A ₁ MODE RESONATORS WITH FREQUENCY UP TO 16 GHZ AND ELECTROMECHANICAL COUPLING FACTOR NEAR 35%	. 1190
T80-h	SUB-3 DB INSERTION LOSS BROADBAND ACOUSTIC DELAY LINES AND HIGH FOM RESONATORS IN LINBO ₃ /SIO ₂ /SI FUNCTIONAL SUBSTRATE	. 1194
W80-h	SUPPRESSION OF SPURIOUS MODES IN ALUMINUM NITRIDE S ₁ LAMB WAVE RESONATORS USING A MECHANICAL SOFT-CONTACT SCHEME	
	h - Optical, RF and Electromagnetics for MEMS/NEMS	
	THz MEMS Components & Systems	
M81-h	TERAHERTZ REFLECTIVE METALENS FOR ARBITRARY OFF-AXIS FOCUSING WITH LARGE DEPTH OF FOCUS Jiahao Miao, Yi Liu, Cong Lin, Zhanxuan Zhou, and Xiaomei Yu Peking University, CHINA	. 1202
	h - Optical, RF and Electromagnetics for MEMS/NEMS	
	Other Electromagnetic MEMS/NEMS	
T81-h	TOWARDS A BETTER CMOS-MEMS RESOSWITCH USING ELECTROLESS PLATING FOR CONTACT ENGINEERING Ting-Jui Liou, Chun-Pu Tsai, Ting-Yi Chen, and Wei-Chang Li National Taiwan University, TAIWAN	. 1206